

## INKJET PRINthead HAVING ISOLATED NOZZLES

### CROSS REFERENCES TO RELATED APPLICATIONS

The following patents or patent applications filed by the applicant or assignee of the  
 5 present invention are hereby incorporated by cross-reference.

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Some applications have been listed by docket numbers. These will be replaced when application numbers are known.

## 5 FIELD OF THE INVENTION

The present invention relates to the field of inkjet printers and, discloses an inkjet printing system using printheads manufactured with microelectro-mechanical systems (MEMS) techniques.

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## BACKGROUND OF THE INVENTION

Many different types of printing have been invented, a large number of which are presently in use. The known forms of print have a variety of methods for marking the print

media with a relevant marking media. Commonly used forms of printing include offset printing, laser printing and copying devices, dot matrix type impact printers, thermal paper printers, film recorders, thermal wax printers, dye sublimation printers and ink jet printers both of the drop on demand and continuous flow type. Each type of printer has its own advantages and problems when considering cost, speed, quality, reliability, simplicity of construction and operation etc.

In recent years, the field of ink jet printing, wherein each individual pixel of ink is derived from one or more ink nozzles has become increasingly popular primarily due to its inexpensive and versatile nature.

Many different techniques on ink jet printing have been invented. For a survey of the field, reference is made to an article by J Moore, "Non-Impact Printing: Introduction and Historical Perspective", Output Hard Copy Devices, Editors R Dubeck and S Sherr, pages 207 - 220 (1988).

Ink Jet printers themselves come in many different types. The utilization of a continuous stream of ink in ink jet printing appears to date back to at least 1929 wherein US Patent No. 1941001 by Hansell discloses a simple form of continuous stream electro-static ink jet printing.

US Patent 3596275 by Sweet also discloses a process of a continuous ink jet printing including the step wherein the ink jet stream is modulated by a high frequency electro-static field so as to cause drop separation. This technique is still utilized by several manufacturers including Elmjet and Scitex (see also US Patent No. 3373437 by Sweet et al)

Piezoelectric ink jet printers are also one form of commonly utilized ink jet printing device. Piezoelectric systems are disclosed by Kyser et. al. in US Patent No. 3946398 (1970) which utilizes a diaphragm mode of operation, by Zolten in US Patent 3683212 (1970) which discloses a squeeze mode of operation of a piezoelectric crystal, Stemme in US Patent No. 3747120 (1972) discloses a bend mode of piezoelectric operation, Howkins in US Patent No. 4459601 discloses a piezoelectric push mode actuation of the ink jet stream and Fischbeck in US 4584590 which discloses a shear mode type of piezoelectric transducer element.

Recently, thermal ink jet printing has become an extremely popular form of ink jet printing. The ink jet printing techniques include those disclosed by Endo et al in GB 2007162 (1979) and Vaught et al in US Patent 4490728. Both the aforementioned references disclosed ink jet printing techniques that rely upon the activation of an electrothermal actuator which results in the creation of a bubble in a constricted space, such as a nozzle, which thereby

causes the ejection of ink from an aperture connected to the confined space onto a relevant print media. Printing devices utilizing the electro-thermal actuator are manufactured by manufacturers such as Canon and Hewlett Packard.

As can be seen from the foregoing, many different types of printing technologies are available. Ideally, a printing technology should have a number of desirable attributes. These include inexpensive construction and operation, high speed operation, safe and continuous long term operation etc. Each technology may have its own advantages and disadvantages in the areas of cost, speed, quality, reliability, power usage, simplicity of construction operation, durability and consumables.

A problem with inkjet printheads, and especially inkjet printheads having a high nozzle density, is that ink can flood across the printhead surface contaminating adjacent nozzles. This is undesirable because it results in reduced print quality. Moreover, cross-contamination of ink across the printhead surface can potentially result in electrolysis and accelerated corrosion of nozzle actuators.

Previous attempts to minimize ink flooding across the printhead surface typically involve coating the printhead with a hydrophobic material. However, hydrophobic coatings have only had limited success in minimizing the extent of flooding.

A further problem with inkjet printheads, especially inkjet printheads having sensitive MEMS nozzles formed on an ink ejection surface of the printhead, is that the nozzle structures can become damaged by cleaning the printhead surface. Typically, printheads are wiped regularly to remove particles of paper dust or paper fibers, which build up on the ink ejection surface. When a wiping mechanism comes into contact with nozzle structures on the printhead surface, there is an obvious risk of damaging the nozzles.

It would be desirable to provide a printhead, which minimizes cross-contamination by ink flooding between adjacent nozzles. It would be further desirable to provide a printhead, which allows regular cleaning of the printhead surface by a wiping mechanism without risk of damaging nozzle structures on the printhead.

## SUMMARY OF THE INVENTION

In a first aspect, there is provided a printhead comprising:

a substrate including a plurality of nozzles for ejecting ink droplets onto a print medium, each nozzle having a nozzle aperture defined in an ink ejection surface of the substrate; and

a plurality of formations on the ink ejection surface, the surface formations being  
5 configured to isolate each nozzle from at least one adjacent nozzle.

In a second aspect, there is provided a method of operating a printhead, whilst minimizing cross-contamination of ink between adjacent nozzles, the method comprising the steps of:

10 (a) providing a printhead comprising:

a substrate including a plurality of nozzles for ejecting ink droplets onto a print medium, each nozzles having a nozzle aperture defined in an ink ejection surface of the substrate; and

a plurality of formations on the ink ejection surface, the surface formations being  
15 configured to isolate each nozzle from at least one adjacent nozzle; and

(b) printing onto a print medium using said printhead.

In a third aspect, there is provided a method of fabricating a printhead having isolated nozzles, the method comprising the steps of:

20 (a) providing a substrate, the substrate including a plurality of nozzles for ejecting ink droplets onto a print medium, each nozzle having a nozzle aperture defined in an ink ejection surface of the substrate;

(b) depositing a layer of photoresist over the ink ejection surface;

(c) defining recesses in the photoresist, each recess revealing a portion of the ink  
25 ejection surface surrounding a respective nozzle aperture;

(d) depositing a roof material over the photoresist and into the recesses;

(e) etching the roof material to define a nozzle enclosure around each nozzle aperture, each nozzle enclosure having an opening defined in a roof and sidewalls extending from the roof to the ink ejection surface; and

30 (f) removing the photoresist.

Optionally, the formations have a hydrophobic surface. Inkjet inks are typically aqueous-based inks and hydrophobic formations will repel any flooded ink. Hence,

hydrophobic formations minimize as far as possible any cross-contamination of ink by acting as a physical barrier and by intermolecular repulsive forces. Moreover, hydrophobic formations promote ingestion of any flooded ink back into respective nozzle chambers and ink supply channels. Since nozzle chambers are typically hydrophilic, ink will tend to be  
5 drawn back into the nozzle and away from a surrounding hydrophobic formation.

Optionally, the formations are arranged in a plurality of nozzle enclosures, each nozzle enclosure comprising sidewalls surrounding a respective nozzle, the sidewalls forming a seal with the ink ejection surface. Hence, each nozzle is isolated from its adjacent nozzles by a nozzle enclosure.

10 Optionally, each nozzle enclosure further comprises a roof spaced apart from the respective nozzle, the roof having a roof opening aligned with a respective nozzle opening for allowing ejected ink droplets to pass therethrough onto the print medium. Hence, each nozzle enclosure may typically take the form of a cap, which covers or encapsulates an individual nozzle on the ink ejection surface. The roof not only provides additional  
15 containment of any flooded ink, it also provides further protection of each nozzle from, for example, the potentially damaging effects of paper dust, paper fibers or wiping.

Typically, the sidewalls extend from a perimeter region of each roof to the ink ejection surface. Sidewalls of adjacent nozzle enclosures are usually spaced apart across the ink ejection surface.

20 Optionally, the printhead is an inkjet printhead, such as a pagewidth inkjet printhead. Optionally, the printhead has a nozzle density, which is sufficient to print at up to 1600 dpi. The present invention is particularly beneficial for printheads having a high nozzle density, because high density printheads are especially prone to flooding between adjacent nozzles.

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## **BRIEF DESCRIPTION OF THE DRAWINGS**

Notwithstanding any other forms that may fall within the scope of the present invention, preferred forms of the invention will now be described, by way of example only, with reference to the accompanying drawings in which:

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Fig. 1 is a schematic cross-sectional view through an ink chamber of a unit cell of a printhead according to an embodiment using a bubble forming heater element;

Fig. 2 is a schematic cross-sectional view through the ink chamber Fig. 1, at another stage of operation;

Fig. 3 is a schematic cross-sectional view through the ink chamber Fig. 1, at yet  
5 another stage of operation;

Fig. 4 is a schematic cross-sectional view through the ink chamber Fig. 1, at yet a further stage of operation; and

10 Fig. 5 is a diagrammatic cross-sectional view through a unit cell of a printhead in accordance with an embodiment of the invention showing the collapse of a vapor bubble.

Fig. 6 is a schematic, partially cut away, perspective view of a further embodiment of a unit cell of a printhead.

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Figs. 7 to 20 are schematic perspective views of the unit cell shown in Fig. 6, at various successive stages in the fabrication process of the printhead.

## DESCRIPTION OF OPTIONAL EMBODIMENTS

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### *Bubble Forming Heater Element Actuator*

With reference to Figures 1 to 4, the unit cell 1 of one of the Applicant's printheads is shown. The unit cell 1 comprises a nozzle plate 2 with nozzles 3 therein, the nozzles having nozzle rims 4, and apertures 5 extending through the nozzle plate. The nozzle plate  
25 2 is plasma etched from a silicon nitride structure which is deposited, by way of chemical vapor deposition (CVD), over a sacrificial material which is subsequently etched.

The printhead also includes, with respect to each nozzle 3, side walls 6 on which the nozzle plate is supported, a chamber 7 defined by the walls and the nozzle plate 2, a multi-  
30 layer substrate 8 and an inlet passage 9 extending through the multi-layer substrate to the far side (not shown) of the substrate. A looped, elongate heater element 10 is suspended within the chamber 7, so that the element is in the form of a suspended beam. The

printhead as shown is a microelectromechanical system (MEMS) structure, which is formed by a lithographic process which is described in more detail below.

When the printhead is in use, ink 11 from a reservoir (not shown) enters the chamber 7 via the inlet passage 9, so that the chamber fills to the level as shown in Figure 1. Thereafter, the heater element 10 is heated for somewhat less than 1 microsecond, so that the heating is in the form of a thermal pulse. It will be appreciated that the heater element 10 is in thermal contact with the ink 11 in the chamber 7 so that when the element is heated, this causes the generation of vapor bubbles 12 in the ink. Accordingly, the ink 11 constitutes a bubble forming liquid. Figure 1 shows the formation of a bubble 12 approximately 1 microsecond after generation of the thermal pulse, that is, when the bubble has just nucleated on the heater elements 10. It will be appreciated that, as the heat is applied in the form of a pulse, all the energy necessary to generate the bubble 12 is to be supplied within that short time.

When the element 10 is heated as described above, the bubble 12 forms along the length of the element, this bubble appearing, in the cross-sectional view of Figure 1, as four bubble portions, one for each of the element portions shown in cross section.

The bubble 12, once generated, causes an increase in pressure within the chamber 7, which in turn causes the ejection of a drop 16 of the ink 11 through the nozzle 3. The rim 4 assists in directing the drop 16 as it is ejected, so as to minimize the chance of drop misdirection.

The reason that there is only one nozzle 3 and chamber 7 per inlet passage 9 is so that the pressure wave generated within the chamber, on heating of the element 10 and forming of a bubble 12, does not affect adjacent chambers and their corresponding nozzles. The pressure wave generated within the chamber creates significant stresses in the chamber wall. Forming the chamber from an amorphous ceramic such as silicon nitride, silicon dioxide (glass) or silicon oxynitride, gives the chamber walls high strength while avoiding the use of material with a crystal structure. Crystalline defects can act as stress concentration points and therefore potential areas of weakness and ultimately failure.

Figures 2 and 3 show the unit cell 1 at two successive later stages of operation of the printhead. It can be seen that the bubble 12 generates further, and hence grows, with the resultant advancement of ink 11 through the nozzle 3. The shape of the bubble 12 as it grows, as shown in Figure 3, is determined by a combination of the inertial dynamics and the surface tension of the ink 11. The surface tension tends to minimize the surface area of the bubble 12 so that, by the time a certain amount of liquid has evaporated, the bubble is essentially disk-shaped.

The increase in pressure within the chamber 7 not only pushes ink 11 out through the nozzle 3, but also pushes some ink back through the inlet passage 9. However, the inlet passage 9 is approximately 200 to 300 microns in length, and is only approximately 16 microns in diameter. Hence there is a substantial viscous drag. As a result, the predominant effect of the pressure rise in the chamber 7 is to force ink out through the nozzle 3 as an ejected drop 16, rather than back through the inlet passage 9.

Turning now to Figure 4, the printhead is shown at a still further successive stage of operation, in which the ink drop 16 that is being ejected is shown during its “necking phase” before the drop breaks off. At this stage, the bubble 12 has already reached its maximum size and has then begun to collapse towards the point of collapse 17, as reflected in more detail in Figure 21.

The collapsing of the bubble 12 towards the point of collapse 17 causes some ink 11 to be drawn from within the nozzle 3 (from the sides 18 of the drop), and some to be drawn from the inlet passage 9, towards the point of collapse. Most of the ink 11 drawn in this manner is drawn from the nozzle 3, forming an annular neck 19 at the base of the drop 16 prior to its breaking off.

The drop 16 requires a certain amount of momentum to overcome surface tension forces, in order to break off. As ink 11 is drawn from the nozzle 3 by the collapse of the bubble 12, the diameter of the neck 19 reduces thereby reducing the amount of total surface tension holding the drop, so that the momentum of the drop as it is ejected out of the nozzle is sufficient to allow the drop to break off.

When the drop 16 breaks off, cavitation forces are caused as reflected by the arrows 20, as the bubble 12 collapses to the point of collapse 17. It will be noted that there are no solid surfaces in the vicinity of the point of collapse 17 on which the cavitation can have an effect.

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### ***Advantages of Nozzle Enclosures***

Referring to Figure 6, an embodiment of the unit cell 1 according to the invention is shown. The aperture 5 is surrounded by a nozzle enclosure 60, which isolates adjacent apertures on the printhead. The nozzle enclosure 60 has a roof 61 and sidewalls 62, which  
10 extend from the roof to the nozzle plate 2 and form a seal therewith. An opening 63 is defined in the roof 61, which allows ink droplets (not shown) to pass through the nozzle enclosure and onto a print medium (not shown).

The nozzle enclosure 60 minimize cross-contamination between adjacent apertures 5 by containing any flooded ink in the immediate vicinity of each nozzle. Flooding of ink  
15 from each nozzle may be caused by a variety of reasons, such as nozzle misfires or pressure fluctuations in ink supply channels. The nozzle enclosure may be formed from or coated with a hydrophobic material during the fabrication process, which further minimizes the risk of cross-contamination.

A further advantage of the printhead according to the invention is that it allows the  
20 nozzle plate 2 of the printhead to be wiped without risk of damaging the sensitive nozzle structures. Typically, inkjet printheads are cleaned by a wiping mechanism as part of a warm-up cycle. The nozzle enclosures 60 provide a protective barrier between the nozzles and the wiping mechanism (not shown).

### ***Fabrication Process***

In the interests of brevity, the fabrication stages have been shown for the unit cell of Figure 6 only (see Figures 7 to 20). It will be appreciated that the other unit cells will use the same fabrication stages with different masking.

30 Referring to Figure 7, there is shown the starting point for fabrication of the thermal inkjet nozzle shown in Figure 13. CMOS processing of a silicon wafer provides a silicon substrate 21 having drive circuitry 22, and an interlayer dielectric ("interconnect") 23. The interconnect 23 comprises four metal layers, which together form a seal ring for the inlet

passage 9 to be etched through the interconnect. The top metal layer 26, which forms an upper portion of the seal ring, can be seen in Figure 7. The metal seal ring prevents ink moisture from seeping into the interconnect 23 when the inlet passage 9 is filled with ink.

5 A passivation layer 24 is deposited onto the top metal layer 26 by plasma-enhanced chemical vapour deposition (PECVD). After deposition of the passivation layer 24, it is etched to define a circular recess, which forms parts of the inlet passage 9. At the same as etching the recess, a plurality of vias 50 are also etched, which allow electrical connection through the passivation layer 24 to the top metal layer 26. The etch pattern is defined by a  
10 layer of patterned photoresist (not shown), which is removed by O<sub>2</sub> ashing after the etch.

Referring to Figure 8, in the next fabrication sequence, a layer of photoresist is spun onto the passivation later 24. The photoresist is exposed and developed to define a circular opening. With the patterned photoresist 51 in place, the dielectric interconnect 23 is etched  
15 as far as the silicon substrate 21 using a suitable oxide-etching gas chemistry (*e.g.* O<sub>2</sub>/C<sub>4</sub>F<sub>8</sub>). Etching through the silicon substrate is continued down to about 20 microns to define a front ink hole 52, using a suitable silicon-etching gas chemistry (*e.g.* 'Bosch etch'). The same photoresist mask 51 can be used for both etching steps. Figure 9 shows the unit cell after etching the front ink hole 52 and removal of the photoresist 51.

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Referring to Figure 10, in the next stage of fabrication, the front ink hole 52 is plugged with photoresist to provide a front plug 53. At the same time, a layer of photoresist is deposited over the passivation layer 24. This layer of photoresist is exposed and developed to define a first sacrificial scaffold 54 over the front plug 53, and scaffolding  
25 tracks 35 around the perimeter of the unit cell. The first sacrificial scaffold 54 is used for subsequent deposition of heater material 38 thereon and is therefore formed with a planar upper surface to avoid any buckling in the heater element (see heater element 10 in Figure 10). The first sacrificial scaffold 54 is UV cured and hardbaked to prevent reflow of the photoresist during subsequent high-temperature deposition onto its upper surface.

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Importantly, the first sacrificial scaffold 54 has sloped or angled side faces 55. These angled side faces 55 are formed by adjusting the focusing in the exposure tool (*e.g.*

stepper) when exposing the photoresist. The sloped side faces 55 advantageously allow heater material 38 to be deposited substantially evenly over the first sacrificial scaffold 54.

Referring to Figure 11, the next stage of fabrication deposits the heater material 38 over the first sacrificial scaffold 54, the passivation layer 24 and the perimeter scaffolding tracks 35. The heater material 38 is typically a monolayer of TiAlN. However, the heater material 38 may alternatively comprise TiAlN sandwiched between upper and lower passivating materials, such as tantalum or tantalum nitride. Passivating layers on the heater element 10 minimize corrosion of the and improve heater longevity.

Referring to Figure 12, the heater material 38 is subsequently etched down to the first sacrificial scaffold 54 to define the heater element 10. At the same time, contact electrodes 15 are defined on either side of the heater element 10. The electrodes 15 are in contact with the top metal layer 26 and so provide electrical connection between the CMOS and the heater element 10. The sloped side faces of the first sacrificial scaffold 54 ensure good electrical connection between the heater element 10 and the electrodes 15, since the heater material is deposited with sufficient thickness around the scaffold 54. Any thin areas of heater material (due to insufficient side face deposition) would increase resistivity and affect heater performance.

Adjacent unit cells are electrically insulated from each other by virtue of grooves etched around the perimeter of each unit cell. The grooves are etched at the same time as defining the heater element 10.

Referring to Figure 13, in the subsequent step a second sacrificial scaffold 39 of photoresist is deposited over the heater material. The second sacrificial scaffold 39 is exposed and developed to define sidewalls for the cylindrical nozzle chamber and perimeter sidewalls for each unit cell. The second sacrificial scaffold 39 is also UV cured and hardbaked to prevent any reflow of the photoresist during subsequent high-temperature deposition of the silicon nitride roof material.

Referring to Figure 14, silicon nitride is deposited onto the second sacrificial scaffold 39 by plasma enhanced chemical vapour deposition. The silicon nitride forms a

roof 44 over each unit cell, which is the nozzle plate 2 for a row of nozzles. Chamber sidewalls 6 and unit cell sidewalls 56 are also formed by deposition of silicon nitride.

Referring to Figure 15, the nozzle rim 4 is etched partially through the roof 44, by  
5 placing a suitably patterned photoresist mask over the roof, etching for a controlled period of time and removing the photoresist by ashing.

Referring to Figure 16, the nozzle aperture 5 is etched through the roof 24 down to  
10 the second sacrificial scaffold 39. Again, the etch is performed by placing a suitably patterned photoresist mask over the roof, etching down to the scaffold 39 and removing the photoresist mask.

Referring to Figure 17, in the next stage a third sacrificial scaffold 64 is deposited  
15 over the roof 44. The third sacrificial scaffold 64 is exposed and developed to define sidewalls for the cylindrical nozzle enclosure over each aperture 5. The third sacrificial scaffold 64 is also UV cured and hardbaked to prevent any reflow of the photoresist during subsequent high-temperature deposition of the nozzle enclosure material.

Referring to Figure 18, silicon nitride is deposited onto the third sacrificial scaffold  
20 64 by plasma enhanced chemical vapour deposition. The silicon nitride forms an enclosure roof 61 over each aperture 5. Enclosure sidewalls 62 are also formed by deposition of silicon nitride. Whilst silicon nitride is deposited in the embodiment shown, the enclosure roof 61 may equally be formed from silicon oxide, silicon oxynitride *etc.* Optionally, a layer of hydrophobic material (*e.g.* fluoropolymer) is deposited onto the enclosure roof 61  
25 after deposition. This extra deposition step may be performed at any stage after deposition (*e.g.* after etching or after ashing).

Referring to Figure 19, the nozzle enclosure 60 is formed by etching through the  
enclosure roof layer 61. The enclosure opening 63 is defined by this etch. In addition, the  
30 enclosure roof material which is located outside the enclosure sidewalls 62 is removed. The etch pattern is defined by standard photoresist masking.

With the nozzle structure, including nozzle enclosure 60, now fully formed on a frontside of the silicon substrate 21, an ink supply channel 32 is etched from the backside of the substrate 21, which meets with the front plug 53.

Referring to Figure 20, after formation of the ink supply channel 32, the first, second and sacrificial scaffolds of photoresist, together with the front plug 53 are ashed off using an O<sub>2</sub> plasma. Accordingly, fluid connection is made from the ink supply channel 32 through to the nozzle aperture 5 and the nozzle enclosure opening 63.

It should be noted that a portion of photoresist, on either side of the nozzle chamber sidewalls 6, remains encapsulated by the roof 44, the unit cell sidewalls 56 and the chamber sidewalls 6. This portion of photoresist is sealed from the O<sub>2</sub> ashing plasma and, therefore, remains intact after fabrication of the printhead. This encapsulated photoresist advantageously provides additional robustness for the printhead by supporting the nozzle plate 2. Hence, the printhead has a robust nozzle plate spanning continuously over rows of nozzles, and being supported by solid blocks of hardened photoresist, in addition to support walls.

### ***Other Embodiments***

The invention has been described above with reference to printheads using bubble forming heater elements. However, it is potentially suited to a wide range of printing system including: color and monochrome office printers, short run digital printers, high speed digital printers, offset press supplemental printers, low cost scanning printers high speed pagewidth printers, notebook computers with inbuilt pagewidth printers, portable color and monochrome printers, color and monochrome copiers, color and monochrome facsimile machines, combined printer, facsimile and copying machines, label printers, large format plotters, photograph copiers, printers for digital photographic “minilabs”, video printers, PHOTO CD (PHOTO CD is a registered trade mark of the Eastman Kodak Company) printers, portable printers for PDAs, wallpaper printers, indoor sign printers, billboard printers, fabric printers, camera printers and fault tolerant commercial printer arrays.

It will be appreciated by ordinary workers in this field that numerous variations and/or modifications may be made to the present invention as shown in the specific embodiments without departing from the spirit or scope of the invention as broadly described. The present embodiments are, therefore, to be considered in all respects to be illustrative and not restrictive.

### Ink Jet Technologies

The embodiments of the invention use an ink jet printer type device. Of course many different devices could be used. However presently popular ink jet printing technologies are unlikely to be suitable.

The most significant problem with thermal ink jet is power consumption. This is approximately 100 times that required for high speed, and stems from the energy-inefficient means of drop ejection. This involves the rapid boiling of water to produce a vapor bubble which expels the ink. Water has a very high heat capacity, and must be superheated in thermal ink jet applications. In conventional thermal inkjet printheads, this leads to an efficiency of around 0.02%, from electricity input to drop momentum (and increased surface area) out.

The most significant problem with piezoelectric ink jet is size and cost. Piezoelectric crystals have a very small deflection at reasonable drive voltages, and therefore require a large area for each nozzle. Also, each piezoelectric actuator must be connected to its drive circuit on a separate substrate. This is not a significant problem at the current limit of around 300 nozzles per printhead, but is a major impediment to the fabrication of pagewidth printheads with 19,200 nozzles.

Ideally, the ink jet technologies used meet the stringent requirements of in-camera digital color printing and other high quality, high speed, low cost printing applications. To meet the requirements of digital photography, new ink jet technologies have been created. The target features include:

- low power (less than 10 Watts)

- high resolution capability (1,600 dpi or more)

photographic quality output

low manufacturing cost

small size (pagewidth times minimum cross section)

high speed ( $< 2$  seconds per page).

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All of these features can be met or exceeded by the ink jet systems described below with differing levels of difficulty. Forty-five different ink jet technologies have been developed by the Assignee to give a wide range of choices for high volume manufacture. These technologies form part of separate applications assigned to the present Assignee as set  
10 out in the table under the heading Cross References to Related Applications.

The ink jet designs shown here are suitable for a wide range of digital printing systems, from battery powered one-time use digital cameras, through to desktop and network printers, and through to commercial printing systems.

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For ease of manufacture using standard process equipment, the printhead is designed to be a monolithic 0.5 micron CMOS chip with MEMS post processing. For color photographic applications, the printhead is 100 mm long, with a width which depends upon the ink jet type. The smallest printhead designed is IJ38, which is 0.35 mm wide, giving a chip area of 35  
20 square mm. The printheads each contain 19,200 nozzles plus data and control circuitry.

Ink is supplied to the back of the printhead by injection molded plastic ink channels. The molding requires 50 micron features, which can be created using a lithographically micromachined insert in a standard injection molding tool. Ink flows through holes etched  
25 through the wafer to the nozzle chambers fabricated on the front surface of the wafer. The printhead is connected to the camera circuitry by tape automated bonding.

#### Tables of Drop-on-Demand Ink Jets

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Eleven important characteristics of the fundamental operation of individual ink jet nozzles have been identified. These characteristics are largely orthogonal, and so can be elucidated as an eleven dimensional matrix. Most of the eleven axes of this matrix include entries developed by the present assignee.

The following tables form the axes of an eleven dimensional table of ink jet types.

Actuator mechanism (18 types)

Basic operation mode (7 types)

Auxiliary mechanism (8 types)

5 Actuator amplification or modification method (17 types)

Actuator motion (19 types)

Nozzle refill method (4 types)

Method of restricting back-flow through inlet (10 types)

Nozzle clearing method (9 types)

10 Nozzle plate construction (9 types)

Drop ejection direction (5 types)

Ink type (7 types)

The complete eleven dimensional table represented by these axes contains 36.9  
15 billion possible configurations of ink jet nozzle. While not all of the possible combinations result in a viable ink jet technology, many million configurations are viable. It is clearly impractical to elucidate all of the possible configurations. Instead, certain ink jet types have been investigated in detail. These are designated IJ01 to IJ45 above which matches the docket numbers in the table under the heading Cross References to Related Applications.

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Other ink jet configurations can readily be derived from these forty-five examples by substituting alternative configurations along one or more of the 11 axes. Most of the IJ01 to IJ45 examples can be made into ink jet printheads with characteristics superior to any currently available ink jet technology.

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Where there are prior art examples known to the inventor, one or more of these examples are listed in the examples column of the tables below. The IJ01 to IJ45 series are also listed in the examples column. In some cases, print technology may be listed more than once in a table, where it shares characteristics with more than one entry.

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Suitable applications for the ink jet technologies include: Home printers, Office network printers, Short run digital printers, Commercial print systems, Fabric printers, Pocket printers, Internet WWW printers, Video printers, Medical imaging, Wide format

printers, Notebook PC printers, Fax machines, Industrial printing systems, Photocopiers, Photographic minilabs etc.

5       The information associated with the aforementioned 11 dimensional matrix are set out in the following tables.

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                                                                  |                                                                                                                                                                                                                                                                                                                                                                                                                                      |                                                                                                                                                                                                                                        |
|---------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                         | Description                                                                                                                                                                                                                                                                                                                              | Advantages                                                                                                                                                                                                                                                                                                       | Disadvantages                                                                                                                                                                                                                                                                                                                                                                                                                        | Examples                                                                                                                                                                                                                               |
| <b>Thermal bubble</b>                                   | <p>An electrothermal heater heats the ink to above boiling point, transferring significant heat to the aqueous ink. A bubble nucleates and quickly forms, expelling the ink.</p> <p>The efficiency of the process is low, with typically less than 0.05% of the electrical energy being transformed into kinetic energy of the drop.</p> | <ul style="list-style-type: none"> <li>◆ Large force generated</li> <li>◆ Simple construction</li> <li>◆ No moving parts</li> <li>◆ Fast operation</li> <li>◆ Small chip area required for actuator</li> </ul>                                                                                                   | <ul style="list-style-type: none"> <li>◆ High power</li> <li>◆ Ink carrier limited to water</li> <li>◆ Low efficiency</li> <li>◆ High temperatures required</li> <li>◆ High mechanical stress</li> <li>◆ Unusual materials required</li> <li>◆ Large drive transistors</li> <li>◆ Cavitation causes actuator failure</li> <li>◆ Kogation reduces bubble formation</li> <li>◆ Large print heads are difficult to fabricate</li> </ul> | <ul style="list-style-type: none"> <li>◆ Canon Bubblejet 1979 Endo et al GB patent 2,007,162</li> <li>◆ Xerox heater-in-pit 1990 Hawkins et al USP 4,899,181</li> <li>◆ Hewlett-Packard TIJ 1982 Vaught et al USP 4,490,728</li> </ul> |
| <b>Piezo-electric</b>                                   | <p>A piezoelectric crystal such as lead lanthanum zirconate (PZT) is electrically activated, and either expands, shears, or bends to apply pressure to the ink, ejecting drops.</p>                                                                                                                                                      | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Fast operation</li> <li>◆ High efficiency</li> </ul>                                                                                                                                             | <ul style="list-style-type: none"> <li>◆ Very large area required for actuator</li> <li>◆ Difficult to integrate with electronics</li> <li>◆ High voltage drive transistors required</li> <li>◆ Full pagewidth print heads impractical due to actuator size</li> <li>◆ Requires electrical poling in high field strengths during manufacture</li> </ul>                                                                              | <ul style="list-style-type: none"> <li>◆ Kyser et al USP 3,946,398</li> <li>◆ Zoltan USP 3,683,212</li> <li>◆ 1973 Stemme USP 3,747,120</li> <li>◆ Epson Stylus</li> <li>◆ Tektronix</li> <li>◆ IJ04</li> </ul>                        |
| <b>Electro-strictive</b>                                | <p>An electric field is used to activate electrostriction in relaxor materials such as lead lanthanum zirconate titanate (PLZT) or lead magnesium niobate (PMN).</p>                                                                                                                                                                     | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Low thermal expansion</li> <li>◆ Electric field strength required (approx. 3.5 V/<math>\mu</math>m) can be generated without difficulty</li> <li>◆ Does not require electrical poling</li> </ul> | <ul style="list-style-type: none"> <li>◆ Low maximum strain (approx. 0.01%)</li> <li>◆ Large area required for actuator due to low strain</li> <li>◆ Response speed is marginal (<math>\sim 10 \mu</math>s)</li> <li>◆ High voltage drive transistors required</li> <li>◆ Full pagewidth print heads impractical due to actuator size</li> </ul>                                                                                     | <ul style="list-style-type: none"> <li>◆ Seiko Epson, Usui et al JP 253401/96</li> <li>◆ IJ04</li> </ul>                                                                                                                               |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                            |                                                                                                                                                                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                                                                                                                                                                                    |                                                                                                                                                    |
|---------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                         | Description                                                                                                                                                                                                                                                                                                                | Advantages                                                                                                                                                                                                                                                                                                                                                      | Disadvantages                                                                                                                                                                                                                                                                                                                                                                                                      | Examples                                                                                                                                           |
| <b>Ferro-electric</b>                                   | An electric field is used to induce a phase transition between the antiferroelectric (AFE) and ferroelectric (FE) phase. Perovskite materials such as tin modified lead lanthanum zirconate titanate (PLZSnT) exhibit large strains of up to 1% associated with the AFE to FE phase transition.                            | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Fast operation (<math>&lt; 1 \mu\text{s}</math>)</li> <li>◆ Relatively high longitudinal strain</li> <li>◆ High efficiency</li> <li>◆ Electric field strength of around <math>3 \text{ V}/\mu\text{m}</math> can be readily provided</li> </ul> | <ul style="list-style-type: none"> <li>◆ Difficult to integrate with electronics</li> <li>◆ Unusual materials such as PLZSnT are required</li> <li>◆ Actuators require a large area</li> </ul>                                                                                                                                                                                                                     | ◆ IJ04                                                                                                                                             |
| <b>Electro-static plates</b>                            | Conductive plates are separated by a compressible or fluid dielectric (usually air). Upon application of a voltage, the plates attract each other and displace ink, causing drop ejection. The conductive plates may be in a comb or honeycomb structure, or stacked to increase the surface area and therefore the force. | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Fast operation</li> </ul>                                                                                                                                                                                                                       | <ul style="list-style-type: none"> <li>◆ Difficult to operate electrostatic devices in an aqueous environment</li> <li>◆ The electrostatic actuator will normally need to be separated from the ink</li> <li>◆ Very large area required to achieve high forces</li> <li>◆ High voltage drive transistors may be required</li> <li>◆ Full pagewidth print heads are not competitive due to actuator size</li> </ul> | ◆ IJ02, IJ04                                                                                                                                       |
| <b>Electro-static pull on ink</b>                       | A strong electric field is applied to the ink, whereupon electrostatic attraction accelerates the ink towards the print medium.                                                                                                                                                                                            | <ul style="list-style-type: none"> <li>◆ Low current consumption</li> <li>◆ Low temperature</li> </ul>                                                                                                                                                                                                                                                          | <ul style="list-style-type: none"> <li>◆ High voltage required</li> <li>◆ May be damaged by sparks due to air breakdown</li> <li>◆ Required field strength increases as the drop size decreases</li> <li>◆ High voltage drive transistors required</li> <li>◆ Electrostatic field attracts dust</li> </ul>                                                                                                         | <ul style="list-style-type: none"> <li>◆ 1989 Saito et al, USP 4,799,068</li> <li>◆ 1989 Miura et al, USP 4,810,954</li> <li>◆ Tone-jet</li> </ul> |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                                                                |                                                                                                                                                                                                                                                        |                                                                                                                                                                                                                                                                                                                                                                                                                                                            |                                                  |
|---------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------|
|                                                         | Description                                                                                                                                                                                                                                                                                                                                                    | Advantages                                                                                                                                                                                                                                             | Disadvantages                                                                                                                                                                                                                                                                                                                                                                                                                                              | Examples                                         |
| <b>Permanent magnet electro-magnetic</b>                | An electromagnet directly attracts a permanent magnet, displacing ink and causing drop ejection. Rare earth magnets with a field strength around 1 Tesla can be used. Examples are: Samarium Cobalt (SaCo) and magnetic materials in the neodymium iron boron family (NdFeB, NdDyFeBNb, NdDyFeB, etc)                                                          | <ul style="list-style-type: none"> <li>♦ Low power consumption</li> <li>♦ Many ink types can be used</li> <li>♦ Fast operation</li> <li>♦ High efficiency</li> <li>♦ Easy extension from single nozzles to pagewidth print heads</li> </ul>            | <ul style="list-style-type: none"> <li>♦ Complex fabrication</li> <li>♦ Permanent magnetic material such as Neodymium Iron Boron (NdFeB) required.</li> <li>♦ High local currents required</li> <li>♦ Copper metalization should be used for long electromigration lifetime and low resistivity</li> <li>♦ Pigmented inks are usually infeasible</li> <li>♦ Operating temperature limited to the Curie temperature (around 540 K)</li> </ul>               | ♦ IJ07, IJ10                                     |
| <b>Soft magnetic core electro-magnetic</b>              | A solenoid induced a magnetic field in a soft magnetic core or yoke fabricated from a ferrous material such as electroplated iron alloys such as CoNiFe [1], CoFe, or NiFe alloys. Typically, the soft magnetic material is in two parts, which are normally held apart by a spring. When the solenoid is actuated, the two parts attract, displacing the ink. | <ul style="list-style-type: none"> <li>♦ Low power consumption</li> <li>♦ Many ink types can be used</li> <li>♦ Fast operation</li> <li>♦ High efficiency</li> <li>♦ Easy extension from single nozzles to pagewidth print heads</li> <li>♦</li> </ul> | <ul style="list-style-type: none"> <li>♦ Complex fabrication</li> <li>♦ Materials not usually present in a CMOS fab such as NiFe, CoNiFe, or CoFe are required</li> <li>♦ High local currents required</li> <li>♦ Copper metalization should be used for long electromigration lifetime and low resistivity</li> <li>♦ Electroplating is required</li> <li>♦ High saturation flux density is required (2.0-2.1 T is achievable with CoNiFe [1])</li> </ul> | ♦ IJ01, IJ05, IJ08, IJ10, IJ12, IJ14, IJ15, IJ17 |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                                              |                                                                                                                                                                                                                                                                    |                                                                                                                                                                                                                                                                                                                                                                                    |                                                                                                                 |
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|                                                         | Description                                                                                                                                                                                                                                                                                                                                  | Advantages                                                                                                                                                                                                                                                         | Disadvantages                                                                                                                                                                                                                                                                                                                                                                      | Examples                                                                                                        |
| <b>Lorenz force</b>                                     | <p>The Lorenz force acting on a current carrying wire in a magnetic field is utilized.</p> <p>This allows the magnetic field to be supplied externally to the print head, for example with rare earth permanent magnets.</p> <p>Only the current carrying wire need be fabricated on the print-head, simplifying materials requirements.</p> | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Fast operation</li> <li>◆ High efficiency</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul>                        | <ul style="list-style-type: none"> <li>◆ Force acts as a twisting motion</li> <li>◆ Typically, only a quarter of the solenoid length provides force in a useful direction</li> <li>◆ High local currents required</li> <li>◆ Copper metalization should be used for long electromigration lifetime and low resistivity</li> <li>◆ Pigmented inks are usually infeasible</li> </ul> | <ul style="list-style-type: none"> <li>◆ IJ06, IJ11, IJ13, IJ16</li> </ul>                                      |
| <b>Magnetostriction</b>                                 | <p>The actuator uses the giant magnetostrictive effect of materials such as Terfenol-D (an alloy of terbium, dysprosium and iron developed at the Naval Ordnance Laboratory, hence Ter-Fe-NOL). For best efficiency, the actuator should be pre-stressed to approx. 8 MPa.</p>                                                               | <ul style="list-style-type: none"> <li>◆ Many ink types can be used</li> <li>◆ Fast operation</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> <li>◆ High force is available</li> </ul>                                                 | <ul style="list-style-type: none"> <li>◆ Force acts as a twisting motion</li> <li>◆ Unusual materials such as Terfenol-D are required</li> <li>◆ High local currents required</li> <li>◆ Copper metalization should be used for long electromigration lifetime and low resistivity</li> <li>◆ Pre-stressing may be required</li> </ul>                                             | <ul style="list-style-type: none"> <li>◆ Fischenbeck, USP 4,032,929</li> <li>◆ IJ25</li> </ul>                  |
| <b>Surface tension reduction</b>                        | <p>Ink under positive pressure is held in a nozzle by surface tension. The surface tension of the ink is reduced below the bubble threshold, causing the ink to egress from the nozzle.</p>                                                                                                                                                  | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Simple construction</li> <li>◆ No unusual materials required in fabrication</li> <li>◆ High efficiency</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul> | <ul style="list-style-type: none"> <li>◆ Requires supplementary force to effect drop separation</li> <li>◆ Requires special ink surfactants</li> <li>◆ Speed may be limited by surfactant properties</li> </ul>                                                                                                                                                                    | <ul style="list-style-type: none"> <li>◆ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul> |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                                                                                                                                                                                        |                                                                                                                                                                                                                                                                                                                                        |                                                                                                                                                                                                          |
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|                                                         | Description                                                                                                                                                                                                              | Advantages                                                                                                                                                                                                                                                                                                                                                                                                                             | Disadvantages                                                                                                                                                                                                                                                                                                                          | Examples                                                                                                                                                                                                 |
| <b>Viscosity reduction</b>                              | The ink viscosity is locally reduced to select which drops are to be ejected. A viscosity reduction can be achieved electrothermally with most inks, but special inks can be engineered for a 100:1 viscosity reduction. | <ul style="list-style-type: none"> <li>◆ Simple construction</li> <li>◆ No unusual materials required in fabrication</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul>                                                                                                                                                                                                                                 | <ul style="list-style-type: none"> <li>◆ Requires supplementary force to effect drop separation</li> <li>◆ Requires special ink viscosity properties</li> <li>◆ High speed is difficult to achieve</li> <li>◆ Requires oscillating ink pressure</li> <li>◆ A high temperature difference (typically 80 degrees) is required</li> </ul> | <ul style="list-style-type: none"> <li>◆ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                                          |
| <b>Acoustic</b>                                         | An acoustic wave is generated and focussed upon the drop ejection region.                                                                                                                                                | <ul style="list-style-type: none"> <li>◆ Can operate without a nozzle plate</li> </ul>                                                                                                                                                                                                                                                                                                                                                 | <ul style="list-style-type: none"> <li>◆ Complex drive circuitry</li> <li>◆ Complex fabrication</li> <li>◆ Low efficiency</li> <li>◆ Poor control of drop position</li> <li>◆ Poor control of drop volume</li> </ul>                                                                                                                   | <ul style="list-style-type: none"> <li>◆ 1993 Hadimioglu et al, EUP 550,192</li> <li>◆ 1993 Elrod et al, EUP 572,220</li> </ul>                                                                          |
| <b>Thermo-elastic bend actuator</b>                     | An actuator which relies upon differential thermal expansion upon Joule heating is used.                                                                                                                                 | <ul style="list-style-type: none"> <li>◆ Low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Simple planar fabrication</li> <li>◆ Small chip area required for each actuator</li> <li>◆ Fast operation</li> <li>◆ High efficiency</li> <li>◆ CMOS compatible voltages and currents</li> <li>◆ Standard MEMS processes can be used</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul> | <ul style="list-style-type: none"> <li>◆ Efficient aqueous operation requires a thermal insulator on the hot side</li> <li>◆ Corrosion prevention can be difficult</li> <li>◆ Pigmented inks may be infeasible, as pigment particles may jam the bend actuator</li> </ul>                                                              | <ul style="list-style-type: none"> <li>◆ IJ03, IJ09, IJ17, IJ18, IJ19, IJ20, IJ21, IJ22, IJ23, IJ24, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ35, IJ36, IJ37, IJ38, IJ39, IJ40, IJ41</li> </ul> |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                     |                                                                                                                                                                                                                                                                                                                                                                                                                                                                              |                                                                                                                                                    |
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|                                                         | Description                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                     | Advantages                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                          | Disadvantages                                                                                                                                                                                                                                                                                                                                                                                                                                                                | Examples                                                                                                                                           |
| <b>High CTE thermo-elastic actuator</b>                 | <p>A material with a very high coefficient of thermal expansion (CTE) such as polytetrafluoroethylene (PTFE) is used. As high CTE materials are usually non-conductive, a heater fabricated from a conductive material is incorporated. A 50 <math>\mu\text{m}</math> long PTFE bend actuator with polysilicon heater and 15 mW power input can provide 180 <math>\mu\text{N}</math> force and 10 <math>\mu\text{m}</math> deflection. Actuator motions include:</p> <p>Bend<br/>Push<br/>Buckle<br/>Rotate</p> | <ul style="list-style-type: none"> <li>◆ High force can be generated</li> <li>◆ Three methods of PTFE deposition are under development: chemical vapor deposition (CVD), spin coating, and evaporation</li> <li>◆ PTFE is a candidate for low dielectric constant insulation in ULSI</li> <li>◆ Very low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Simple planar fabrication</li> <li>◆ Small chip area required for each actuator</li> <li>◆ Fast operation</li> <li>◆ High efficiency</li> <li>◆ CMOS compatible voltages and currents</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul> | <ul style="list-style-type: none"> <li>◆ Requires special material (e.g. PTFE)</li> <li>◆ Requires a PTFE deposition process, which is not yet standard in ULSI fabs</li> <li>◆ PTFE deposition cannot be followed with high temperature (above 350 °C) processing</li> <li>◆ Pigmented inks may be infeasible, as pigment particles may jam the bend actuator</li> </ul>                                                                                                    | <ul style="list-style-type: none"> <li>◆ IJ09, IJ17, IJ18, IJ20, IJ21, IJ22, IJ23, IJ24, IJ27, IJ28, IJ29, IJ30, IJ31, IJ42, IJ43, IJ44</li> </ul> |
| <b>Conduct-ive polymer thermo-elastic actuator</b>      | <p>A polymer with a high coefficient of thermal expansion (such as PTFE) is doped with conducting substances to increase its conductivity to about 3 orders of magnitude below that of copper. The conducting polymer expands when resistively heated.</p> <p>Examples of conducting dopants include:</p> <p>Carbon nanotubes<br/>Metal fibers<br/>Conductive polymers such as doped polythiophene<br/>Carbon granules</p>                                                                                      | <ul style="list-style-type: none"> <li>◆ High force can be generated</li> <li>◆ Very low power consumption</li> <li>◆ Many ink types can be used</li> <li>◆ Simple planar fabrication</li> <li>◆ Small chip area required for each actuator</li> <li>◆ Fast operation</li> <li>◆ High efficiency</li> <li>◆ CMOS compatible voltages and currents</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> </ul>                                                                                                                                                                                                                 | <ul style="list-style-type: none"> <li>◆ Requires special materials development (High CTE conductive polymer)</li> <li>◆ Requires a PTFE deposition process, which is not yet standard in ULSI fabs</li> <li>◆ PTFE deposition cannot be followed with high temperature (above 350 °C) processing</li> <li>◆ Evaporation and CVD deposition techniques cannot be used</li> <li>◆ Pigmented inks may be infeasible, as pigment particles may jam the bend actuator</li> </ul> | <ul style="list-style-type: none"> <li>◆ IJ24</li> </ul>                                                                                           |

| ACTUATOR MECHANISM (APPLIED ONLY TO SELECTED INK DROPS) |                                                                                                                                                                                                                                                                                                                                                                             |                                                                                                                                                                                                                                                                                                                                           |                                                                                                                                                                                                                                                                                                                                                                                                                               |          |
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|                                                         | Description                                                                                                                                                                                                                                                                                                                                                                 | Advantages                                                                                                                                                                                                                                                                                                                                | Disadvantages                                                                                                                                                                                                                                                                                                                                                                                                                 | Examples |
| <b>Shape memory alloy</b>                               | A shape memory alloy such as TiNi (also known as Nitinol - Nickel Titanium alloy developed at the Naval Ordnance Laboratory) is thermally switched between its weak martensitic state and its high stiffness austenitic state. The shape of the actuator in its martensitic state is deformed relative to the austenitic shape. The shape change causes ejection of a drop. | <ul style="list-style-type: none"> <li>◆ High force is available (stresses of hundreds of MPa)</li> <li>◆ Large strain is available (more than 3%)</li> <li>◆ High corrosion resistance</li> <li>◆ Simple construction</li> <li>◆ Easy extension from single nozzles to pagewidth print heads</li> <li>◆ Low voltage operation</li> </ul> | <ul style="list-style-type: none"> <li>◆ Fatigue limits maximum number of cycles</li> <li>◆ Low strain (1%) is required to extend fatigue resistance</li> <li>◆ Cycle rate limited by heat removal</li> <li>◆ Requires unusual materials (TiNi)</li> <li>◆ The latent heat of transformation must be provided</li> <li>◆ High current operation</li> <li>◆ Requires pre-stressing to distort the martensitic state</li> </ul> | ◆ IJ26   |
| <b>Linear Magnetic Actuator</b>                         | Linear magnetic actuators include the Linear Induction Actuator (LIA), Linear Permanent Magnet Synchronous Actuator (LPMSA), Linear Reluctance Synchronous Actuator (LRSA), Linear Switched Reluctance Actuator (LSRA), and the Linear Stepper Actuator (LSA).                                                                                                              | <ul style="list-style-type: none"> <li>◆ Linear Magnetic actuators can be constructed with high thrust, long travel, and high efficiency using planar semiconductor fabrication techniques</li> <li>◆ Long actuator travel is available</li> <li>◆ Medium force is available</li> <li>◆ Low voltage operation</li> </ul>                  | <ul style="list-style-type: none"> <li>◆ Requires unusual semiconductor materials such as soft magnetic alloys (e.g. CoNiFe)</li> <li>◆ Some varieties also require permanent magnetic materials such as Neodymium iron boron (NdFeB)</li> <li>◆ Requires complex multi-phase drive circuitry</li> <li>◆ High current operation</li> </ul>                                                                                    | ◆ IJ12   |

| BASIC OPERATION MODE |             |            |               |          |
|----------------------|-------------|------------|---------------|----------|
|                      | Description | Advantages | Disadvantages | Examples |

| BASIC OPERATION MODE                |                                                                                                                                                                                                                                           |                                                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                                                                                                                                       |                                                                                                                                                                                                                                                                                                                                  |
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|                                     | Description                                                                                                                                                                                                                               | Advantages                                                                                                                                                                                                                                      | Disadvantages                                                                                                                                                                                                                                                                                                                                                         | Examples                                                                                                                                                                                                                                                                                                                         |
| <b>Actuator directly pushes ink</b> | This is the simplest mode of operation: the actuator directly supplies sufficient kinetic energy to expel the drop. The drop must have a sufficient velocity to overcome the surface tension.                                             | <ul style="list-style-type: none"> <li>Simple operation</li> <li>No external fields required</li> <li>Satellite drops can be avoided if drop velocity is less than 4 m/s</li> <li>Can be efficient, depending upon the actuator used</li> </ul> | <ul style="list-style-type: none"> <li>Drop repetition rate is usually limited to around 10 kHz. However, this is not fundamental to the method, but is related to the refill method normally used</li> <li>All of the drop kinetic energy must be provided by the actuator</li> <li>Satellite drops usually form if drop velocity is greater than 4.5 m/s</li> </ul> | <ul style="list-style-type: none"> <li>Thermal ink jet</li> <li>Piezoelectric ink jet</li> <li>IJ01, IJ02, IJ03, IJ04, IJ05, IJ06, IJ07, IJ09, IJ11, IJ12, IJ14, IJ16, IJ20, IJ22, IJ23, IJ24, IJ25, IJ26, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ35, IJ36, IJ37, IJ38, IJ39, IJ40, IJ41, IJ42, IJ43, IJ44</li> </ul> |
| <b>Proximity</b>                    | The drops to be printed are selected by some manner (e.g. thermally induced surface tension reduction of pressurized ink). Selected drops are separated from the ink in the nozzle by contact with the print medium or a transfer roller. | <ul style="list-style-type: none"> <li>Very simple print head fabrication can be used</li> <li>The drop selection means does not need to provide the energy required to separate the drop from the nozzle</li> </ul>                            | <ul style="list-style-type: none"> <li>Requires close proximity between the print head and the print media or transfer roller</li> <li>May require two print heads printing alternate rows of the image</li> <li>Monolithic color print heads are difficult</li> </ul>                                                                                                | <ul style="list-style-type: none"> <li>Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                                                                                                                                                                    |
| <b>Electro-static pull on ink</b>   | The drops to be printed are selected by some manner (e.g. thermally induced surface tension reduction of pressurized ink). Selected drops are separated from the ink in the nozzle by a strong electric field.                            | <ul style="list-style-type: none"> <li>Very simple print head fabrication can be used</li> <li>The drop selection means does not need to provide the energy required to separate the drop from the nozzle</li> </ul>                            | <ul style="list-style-type: none"> <li>Requires very high electrostatic field</li> <li>Electrostatic field for small nozzle sizes is above air breakdown</li> <li>Electrostatic field may attract dust</li> </ul>                                                                                                                                                     | <ul style="list-style-type: none"> <li>Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>Tone-Jet</li> </ul>                                                                                                                                                                                                  |
| <b>Magnetic pull on ink</b>         | The drops to be printed are selected by some manner (e.g. thermally induced surface tension reduction of pressurized ink). Selected drops are separated from the ink in the nozzle by a strong magnetic field acting on the magnetic ink. | <ul style="list-style-type: none"> <li>Very simple print head fabrication can be used</li> <li>The drop selection means does not need to provide the energy required to separate the drop from the nozzle</li> </ul>                            | <ul style="list-style-type: none"> <li>Requires magnetic ink</li> <li>Ink colors other than black are difficult</li> <li>Requires very high magnetic fields</li> </ul>                                                                                                                                                                                                | <ul style="list-style-type: none"> <li>Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                                                                                                                                                                    |

| <b>BASIC OPERATION MODE</b>               |                                                                                                                                                                                            |                                                                                                                                                                                                                             |                                                                                                                                                                                                               |                          |
|-------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------|
|                                           | <b>Description</b>                                                                                                                                                                         | <b>Advantages</b>                                                                                                                                                                                                           | <b>Disadvantages</b>                                                                                                                                                                                          | <b>Examples</b>          |
| <b>Shutter</b>                            | The actuator moves a shutter to block ink flow to the nozzle. The ink pressure is pulsed at a multiple of the drop ejection frequency.                                                     | <ul style="list-style-type: none"> <li>♦ High speed (&gt;50 kHz) operation can be achieved due to reduced refill time</li> <li>♦ Drop timing can be very accurate</li> <li>♦ The actuator energy can be very low</li> </ul> | <ul style="list-style-type: none"> <li>♦ Moving parts are required</li> <li>♦ Requires ink pressure modulator</li> <li>♦ Friction and wear must be considered</li> <li>♦ Stiction is possible</li> </ul>      | ♦ IJ13, IJ17, IJ21       |
| <b>Shuttered grill</b>                    | The actuator moves a shutter to block ink flow through a grill to the nozzle. The shutter movement need only be equal to the width of the grill holes.                                     | <ul style="list-style-type: none"> <li>♦ Actuators with small travel can be used</li> <li>♦ Actuators with small force can be used</li> <li>♦ High speed (&gt;50 kHz) operation can be achieved</li> </ul>                  | <ul style="list-style-type: none"> <li>♦ Moving parts are required</li> <li>♦ Requires ink pressure modulator</li> <li>♦ Friction and wear must be considered</li> <li>♦ Stiction is possible</li> </ul>      | ♦ IJ08, IJ15, IJ18, IJ19 |
| <b>Pulsed magnetic pull on ink pusher</b> | A pulsed magnetic field attracts an 'ink pusher' at the drop ejection frequency. An actuator controls a catch, which prevents the ink pusher from moving when a drop is not to be ejected. | <ul style="list-style-type: none"> <li>♦ Extremely low energy operation is possible</li> <li>♦ No heat dissipation problems</li> </ul>                                                                                      | <ul style="list-style-type: none"> <li>♦ Requires an external pulsed magnetic field</li> <li>♦ Requires special materials for both the actuator and the ink pusher</li> <li>♦ Complex construction</li> </ul> | ♦ IJ10                   |

| AUXILIARY MECHANISM (APPLIED TO ALL NOZZLES)              |                                                                                                                                                                                                                                                                                                  |                                                                                                                                                                                                                                                                               |                                                                                                                                                                                                                                                |                                                                                                                                                                                                                                                                                                                                      |
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|                                                           | Description                                                                                                                                                                                                                                                                                      | Advantages                                                                                                                                                                                                                                                                    | Disadvantages                                                                                                                                                                                                                                  | Examples                                                                                                                                                                                                                                                                                                                             |
| None                                                      | The actuator directly fires the ink drop, and there is no external field or other mechanism required.                                                                                                                                                                                            | <ul style="list-style-type: none"> <li>♦ Simplicity of construction</li> <li>♦ Simplicity of operation</li> <li>♦ Small physical size</li> </ul>                                                                                                                              | <ul style="list-style-type: none"> <li>♦ Drop ejection energy must be supplied by individual nozzle actuator</li> </ul>                                                                                                                        | <ul style="list-style-type: none"> <li>♦ Most ink jets, including piezoelectric and thermal bubble.</li> <li>♦ IJ01, IJ02, IJ03, IJ04, IJ05, IJ07, IJ09, IJ11, IJ12, IJ14, IJ20, IJ22, IJ23, IJ24, IJ25, IJ26, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ35, IJ36, IJ37, IJ38, IJ39, IJ40, IJ41, IJ42, IJ43, IJ44</li> </ul> |
| Oscillating ink pressure (including acoustic stimulation) | The ink pressure oscillates, providing much of the drop ejection energy. The actuator selects which drops are to be fired by selectively blocking or enabling nozzles. The ink pressure oscillation may be achieved by vibrating the print head, or preferably by an actuator in the ink supply. | <ul style="list-style-type: none"> <li>♦ Oscillating ink pressure can provide a refill pulse, allowing higher operating speed</li> <li>♦ The actuators may operate with much lower energy</li> <li>♦ Acoustic lenses can be used to focus the sound on the nozzles</li> </ul> | <ul style="list-style-type: none"> <li>♦ Requires external ink pressure oscillator</li> <li>♦ Ink pressure phase and amplitude must be carefully controlled</li> <li>♦ Acoustic reflections in the ink chamber must be designed for</li> </ul> | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ IJ08, IJ13, IJ15, IJ17, IJ18, IJ19, IJ21</li> </ul>                                                                                                                                                                  |
| Media proximity                                           | The print head is placed in close proximity to the print medium. Selected drops protrude from the print head further than unselected drops, and contact the print medium. The drop soaks into the medium fast enough to cause drop separation.                                                   | <ul style="list-style-type: none"> <li>♦ Low power</li> <li>♦ High accuracy</li> <li>♦ Simple print head construction</li> </ul>                                                                                                                                              | <ul style="list-style-type: none"> <li>♦ Precision assembly required</li> <li>♦ Paper fibers may cause problems</li> <li>♦ Cannot print on rough substrates</li> </ul>                                                                         | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                                                                                                                                                                      |
| Transfer roller                                           | Drops are printed to a transfer roller instead of straight to the print medium. A transfer roller can also be used for proximity drop separation.                                                                                                                                                | <ul style="list-style-type: none"> <li>♦ High accuracy</li> <li>♦ Wide range of print substrates can be used</li> <li>♦ Ink can be dried on the transfer roller</li> </ul>                                                                                                    | <ul style="list-style-type: none"> <li>♦ Bulky</li> <li>♦ Expensive</li> <li>♦ Complex construction</li> </ul>                                                                                                                                 | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ Tektronix hot melt piezoelectric ink jet</li> <li>♦ Any of the IJ series</li> </ul>                                                                                                                                  |

| <b>AUXILIARY MECHANISM (APPLIED TO ALL NOZZLES)</b> |                                                                                                                                                                             |                                                                                                                                                  |                                                                                                                                                               |                                                                                                                                     |
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|                                                     | <b>Description</b>                                                                                                                                                          | <b>Advantages</b>                                                                                                                                | <b>Disadvantages</b>                                                                                                                                          | <b>Examples</b>                                                                                                                     |
| <b>Electro-static</b>                               | An electric field is used to accelerate selected drops towards the print medium.                                                                                            | <ul style="list-style-type: none"> <li>♦ Low power</li> <li>♦ Simple print head construction</li> </ul>                                          | <ul style="list-style-type: none"> <li>♦ Field strength required for separation of small drops is near or above air breakdown</li> </ul>                      | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ Tone-Jet</li> </ul> |
| <b>Direct magnetic field</b>                        | A magnetic field is used to accelerate selected drops of magnetic ink towards the print medium.                                                                             | <ul style="list-style-type: none"> <li>♦ Low power</li> <li>♦ Simple print head construction</li> </ul>                                          | <ul style="list-style-type: none"> <li>♦ Requires magnetic ink</li> <li>♦ Requires strong magnetic field</li> </ul>                                           | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                     |
| <b>Cross magnetic field</b>                         | The print head is placed in a constant magnetic field. The Lorentz force in a current carrying wire is used to move the actuator.                                           | <ul style="list-style-type: none"> <li>♦ Does not require magnetic materials to be integrated in the print head manufacturing process</li> </ul> | <ul style="list-style-type: none"> <li>♦ Requires external magnet</li> <li>♦ Current densities may be high, resulting in electromigration problems</li> </ul> | <ul style="list-style-type: none"> <li>♦ IJ06, IJ16</li> </ul>                                                                      |
| <b>Pulsed magnetic field</b>                        | A pulsed magnetic field is used to cyclically attract a paddle, which pushes on the ink. A small actuator moves a catch, which selectively prevents the paddle from moving. | <ul style="list-style-type: none"> <li>♦ Very low power operation is possible</li> <li>♦ Small print head size</li> </ul>                        | <ul style="list-style-type: none"> <li>♦ Complex print head construction</li> <li>♦ Magnetic materials required in print head</li> </ul>                      | <ul style="list-style-type: none"> <li>♦ IJ10</li> </ul>                                                                            |

| ACTUATOR AMPLIFICATION OR MODIFICATION METHOD |                                                                                                                                                                                                                                                                  |                                                                                                                                                                                                        |                                                                                                                                                                                                                                      |                                                                                                                                                                                                                               |
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|                                               | Description                                                                                                                                                                                                                                                      | Advantages                                                                                                                                                                                             | Disadvantages                                                                                                                                                                                                                        | Examples                                                                                                                                                                                                                      |
| None                                          | No actuator mechanical amplification is used. The actuator directly drives the drop ejection process.                                                                                                                                                            | <ul style="list-style-type: none"> <li>Operational simplicity</li> </ul>                                                                                                                               | <ul style="list-style-type: none"> <li>Many actuator mechanisms have insufficient travel, or insufficient force, to efficiently drive the drop ejection process</li> </ul>                                                           | <ul style="list-style-type: none"> <li>Thermal Bubble Ink jet</li> <li>IJ01, IJ02, IJ06, IJ07, IJ16, IJ25, IJ26</li> </ul>                                                                                                    |
| Differential expansion bend actuator          | An actuator material expands more on one side than on the other. The expansion may be thermal, piezoelectric, magnetostrictive, or other mechanism. The bend actuator converts a high force low travel actuator mechanism to high travel, lower force mechanism. | <ul style="list-style-type: none"> <li>Provides greater travel in a reduced print head area</li> </ul>                                                                                                 | <ul style="list-style-type: none"> <li>High stresses are involved</li> <li>Care must be taken that the materials do not delaminate</li> <li>Residual bend resulting from high temperature or high stress during formation</li> </ul> | <ul style="list-style-type: none"> <li>Piezoelectric</li> <li>IJ03, IJ09, IJ17, IJ18, IJ19, IJ20, IJ21, IJ22, IJ23, IJ24, IJ27, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ35, IJ36, IJ37, IJ38, IJ39, IJ42, IJ43, IJ44</li> </ul> |
| Transient bend actuator                       | A trilayer bend actuator where the two outside layers are identical. This cancels bend due to ambient temperature and residual stress. The actuator only responds to transient heating of one side or the other.                                                 | <ul style="list-style-type: none"> <li>Very good temperature stability</li> <li>High speed, as a new drop can be fired before heat dissipates</li> <li>Cancels residual stress of formation</li> </ul> | <ul style="list-style-type: none"> <li>High stresses are involved</li> <li>Care must be taken that the materials do not delaminate</li> </ul>                                                                                        | <ul style="list-style-type: none"> <li>IJ40, IJ41</li> </ul>                                                                                                                                                                  |
| Reverse spring                                | The actuator loads a spring. When the actuator is turned off, the spring releases. This can reverse the force/distance curve of the actuator to make it compatible with the force/time requirements of the drop ejection.                                        | <ul style="list-style-type: none"> <li>Better coupling to the ink</li> </ul>                                                                                                                           | <ul style="list-style-type: none"> <li>Fabrication complexity</li> <li>High stress in the spring</li> </ul>                                                                                                                          | <ul style="list-style-type: none"> <li>IJ05, IJ11</li> </ul>                                                                                                                                                                  |
| Actuator stack                                | A series of thin actuators are stacked. This can be appropriate where actuators require high electric field strength, such as electrostatic and piezoelectric actuators.                                                                                         | <ul style="list-style-type: none"> <li>Increased travel</li> <li>Reduced drive voltage</li> </ul>                                                                                                      | <ul style="list-style-type: none"> <li>Increased fabrication complexity</li> <li>Increased possibility of short circuits due to pinholes</li> </ul>                                                                                  | <ul style="list-style-type: none"> <li>Some piezoelectric ink jets</li> <li>IJ04</li> </ul>                                                                                                                                   |

| ACTUATOR AMPLIFICATION OR MODIFICATION METHOD |                                                                                                                                                                                                                                                                       |                                                                                                                                                                               |                                                                                                                                                                                                                                                    |                                                                                                  |
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|                                               | Description                                                                                                                                                                                                                                                           | Advantages                                                                                                                                                                    | Disadvantages                                                                                                                                                                                                                                      | Examples                                                                                         |
| <b>Multiple actuators</b>                     | Multiple smaller actuators are used simultaneously to move the ink. Each actuator need provide only a portion of the force required.                                                                                                                                  | <ul style="list-style-type: none"> <li>Increases the force available from an actuator</li> <li>Multiple actuators can be positioned to control ink flow accurately</li> </ul> | <ul style="list-style-type: none"> <li>Actuator forces may not add linearly, reducing efficiency</li> </ul>                                                                                                                                        | <ul style="list-style-type: none"> <li>IJ12, IJ13, IJ18, IJ20, IJ22, IJ28, IJ42, IJ43</li> </ul> |
| <b>Linear Spring</b>                          | A linear spring is used to transform a motion with small travel and high force into a longer travel, lower force motion.                                                                                                                                              | <ul style="list-style-type: none"> <li>Matches low travel actuator with higher travel requirements</li> <li>Non-contact method of motion transformation</li> </ul>            | <ul style="list-style-type: none"> <li>Requires print head area for the spring</li> </ul>                                                                                                                                                          | <ul style="list-style-type: none"> <li>IJ15</li> </ul>                                           |
| <b>Coiled actuator</b>                        | A bend actuator is coiled to provide greater travel in a reduced chip area.                                                                                                                                                                                           | <ul style="list-style-type: none"> <li>Increases travel</li> <li>Reduces chip area</li> <li>Planar implementations are relatively easy to fabricate.</li> </ul>               | <ul style="list-style-type: none"> <li>Generally restricted to planar implementations due to extreme fabrication difficulty in other orientations.</li> </ul>                                                                                      | <ul style="list-style-type: none"> <li>IJ17, IJ21, IJ34, IJ35</li> </ul>                         |
| <b>Flexure bend actuator</b>                  | A bend actuator has a small region near the fixture point, which flexes much more readily than the remainder of the actuator. The actuator flexing is effectively converted from an even coiling to an angular bend, resulting in greater travel of the actuator tip. | <ul style="list-style-type: none"> <li>Simple means of increasing travel of a bend actuator</li> </ul>                                                                        | <ul style="list-style-type: none"> <li>Care must be taken not to exceed the elastic limit in the flexure area</li> <li>Stress distribution is very uneven</li> <li>Difficult to accurately model with finite element analysis</li> </ul>           | <ul style="list-style-type: none"> <li>IJ10, IJ19, IJ33</li> </ul>                               |
| <b>Catch</b>                                  | The actuator controls a small catch. The catch either enables or disables movement of an ink pusher that is controlled in a bulk manner.                                                                                                                              | <ul style="list-style-type: none"> <li>Very low actuator energy</li> <li>Very small actuator size</li> </ul>                                                                  | <ul style="list-style-type: none"> <li>Complex construction</li> <li>Requires external force</li> <li>Unsuitable for pigmented inks</li> </ul>                                                                                                     | <ul style="list-style-type: none"> <li>IJ10</li> </ul>                                           |
| <b>Gears</b>                                  | Gears can be used to increase travel at the expense of duration. Circular gears, rack and pinion, ratchets, and other gearing methods can be used.                                                                                                                    | <ul style="list-style-type: none"> <li>Low force, low travel actuators can be used</li> <li>Can be fabricated using standard surface MEMS processes</li> </ul>                | <ul style="list-style-type: none"> <li>Moving parts are required</li> <li>Several actuator cycles are required</li> <li>More complex drive electronics</li> <li>Complex construction</li> <li>Friction, friction, and wear are possible</li> </ul> | <ul style="list-style-type: none"> <li>IJ13</li> </ul>                                           |

| ACTUATOR AMPLIFICATION OR MODIFICATION METHOD |                                                                                                                                                                                                            |                                                                                                                                                                                                                         |                                                                                                                                                                                                         |                                                                                                                                                                                     |
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|                                               | Description                                                                                                                                                                                                | Advantages                                                                                                                                                                                                              | Disadvantages                                                                                                                                                                                           | Examples                                                                                                                                                                            |
| <b>Buckle plate</b>                           | A buckle plate can be used to change a slow actuator into a fast motion. It can also convert a high force, low travel actuator into a high travel, medium force motion.                                    | <ul style="list-style-type: none"> <li>♦ Very fast movement achievable</li> </ul>                                                                                                                                       | <ul style="list-style-type: none"> <li>♦ Must stay within elastic limits of the materials for long device life</li> <li>♦ High stresses involved</li> <li>♦ Generally high power requirement</li> </ul> | <ul style="list-style-type: none"> <li>♦ S. Hirata et al, "An Ink-jet Head Using Diaphragm Microactuator", Proc. IEEE MEMS, Feb. 1996, pp 418-423.</li> <li>♦ IJ18, IJ27</li> </ul> |
| <b>Tapered magnetic pole</b>                  | A tapered magnetic pole can increase travel at the expense of force.                                                                                                                                       | <ul style="list-style-type: none"> <li>♦ Linearizes the magnetic force/distance curve</li> </ul>                                                                                                                        | <ul style="list-style-type: none"> <li>♦ Complex construction</li> </ul>                                                                                                                                | <ul style="list-style-type: none"> <li>♦ IJ14</li> </ul>                                                                                                                            |
| <b>Lever</b>                                  | A lever and fulcrum is used to transform a motion with small travel and high force into a motion with longer travel and lower force. The lever can also reverse the direction of travel.                   | <ul style="list-style-type: none"> <li>♦ Matches low travel actuator with higher travel requirements</li> <li>♦ Fulcrum area has no linear movement, and can be used for a fluid seal</li> </ul>                        | <ul style="list-style-type: none"> <li>♦ High stress around the fulcrum</li> </ul>                                                                                                                      | <ul style="list-style-type: none"> <li>♦ IJ32, IJ36, IJ37</li> </ul>                                                                                                                |
| <b>Rotary impeller</b>                        | The actuator is connected to a rotary impeller. A small angular deflection of the actuator results in a rotation of the impeller vanes, which push the ink against stationary vanes and out of the nozzle. | <ul style="list-style-type: none"> <li>♦ High mechanical advantage</li> <li>♦ The ratio of force to travel of the actuator can be matched to the nozzle requirements by varying the number of impeller vanes</li> </ul> | <ul style="list-style-type: none"> <li>♦ Complex construction</li> <li>♦ Unsuitable for pigmented inks</li> </ul>                                                                                       | <ul style="list-style-type: none"> <li>♦ IJ28</li> </ul>                                                                                                                            |
| <b>Acoustic lens</b>                          | A refractive or diffractive (e.g. zone plate) acoustic lens is used to concentrate sound waves.                                                                                                            | <ul style="list-style-type: none"> <li>♦ No moving parts</li> </ul>                                                                                                                                                     | <ul style="list-style-type: none"> <li>♦ Large area required</li> <li>♦ Only relevant for acoustic ink jets</li> </ul>                                                                                  | <ul style="list-style-type: none"> <li>♦ 1993 Hadimioglu et al, EUP 550,192</li> <li>♦ 1993 Elrod et al, EUP 572,220</li> </ul>                                                     |
| <b>Sharp conductive point</b>                 | A sharp point is used to concentrate an electrostatic field.                                                                                                                                               | <ul style="list-style-type: none"> <li>♦ Simple construction</li> </ul>                                                                                                                                                 | <ul style="list-style-type: none"> <li>♦ Difficult to fabricate using standard VLSI processes for a surface ejecting ink-jet</li> <li>♦ Only relevant for electrostatic ink jets</li> </ul>             | <ul style="list-style-type: none"> <li>♦ Tone-jet</li> </ul>                                                                                                                        |

| ACTUATOR MOTION                       |                                                                                                                                                                                |                                                                                                                                                           |                                                                                                                                                                                                            |                                                                                                                                                                                                           |
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|                                       | Description                                                                                                                                                                    | Advantages                                                                                                                                                | Disadvantages                                                                                                                                                                                              | Examples                                                                                                                                                                                                  |
| <b>Volume expansion</b>               | The volume of the actuator changes, pushing the ink in all directions.                                                                                                         | <ul style="list-style-type: none"> <li>Simple construction in the case of thermal ink jet</li> </ul>                                                      | <ul style="list-style-type: none"> <li>High energy is typically required to achieve volume expansion. This leads to thermal stress, cavitation, and kagation in thermal ink jet implementations</li> </ul> | <ul style="list-style-type: none"> <li>Hewlett-Packard Thermal Ink jet</li> <li>Canon Bubblejet</li> </ul>                                                                                                |
| <b>Linear, normal to chip surface</b> | The actuator moves in a direction normal to the print head surface. The nozzle is typically in the line of movement.                                                           | <ul style="list-style-type: none"> <li>Efficient coupling to ink drops ejected normal to the surface</li> </ul>                                           | <ul style="list-style-type: none"> <li>High fabrication complexity may be required to achieve perpendicular motion</li> </ul>                                                                              | <ul style="list-style-type: none"> <li>IJ01, IJ02, IJ04, IJ07, IJ11, IJ14</li> </ul>                                                                                                                      |
| <b>Parallel to chip surface</b>       | The actuator moves parallel to the print head surface. Drop ejection may still be normal to the surface.                                                                       | <ul style="list-style-type: none"> <li>Suitable for planar fabrication</li> </ul>                                                                         | <ul style="list-style-type: none"> <li>Fabrication complexity</li> <li>Friction</li> <li>Stiction</li> </ul>                                                                                               | <ul style="list-style-type: none"> <li>IJ12, IJ13, IJ15, IJ33, , IJ34, IJ35, IJ36</li> </ul>                                                                                                              |
| <b>Membrane push</b>                  | An actuator with a high force but small area is used to push a stiff membrane that is in contact with the ink.                                                                 | <ul style="list-style-type: none"> <li>The effective area of the actuator becomes the membrane area</li> </ul>                                            | <ul style="list-style-type: none"> <li>Fabrication complexity</li> <li>Actuator size</li> <li>Difficulty of integration in a VLSI process</li> </ul>                                                       | <ul style="list-style-type: none"> <li>1982 Howkins USP 4,459,601</li> </ul>                                                                                                                              |
| <b>Rotary</b>                         | The actuator causes the rotation of some element, such a grill or impeller                                                                                                     | <ul style="list-style-type: none"> <li>Rotary levers may be used to increase travel</li> <li>Small chip area requirements</li> </ul>                      | <ul style="list-style-type: none"> <li>Device complexity</li> <li>May have friction at a pivot point</li> </ul>                                                                                            | <ul style="list-style-type: none"> <li>IJ05, IJ08, IJ13, IJ28</li> </ul>                                                                                                                                  |
| <b>Bend</b>                           | The actuator bends when energized. This may be due to differential thermal expansion, piezoelectric expansion, magnetostriction, or other form of relative dimensional change. | <ul style="list-style-type: none"> <li>A very small change in dimensions can be converted to a large motion.</li> </ul>                                   | <ul style="list-style-type: none"> <li>Requires the actuator to be made from at least two distinct layers, or to have a thermal difference across the actuator</li> </ul>                                  | <ul style="list-style-type: none"> <li>1970 Kyser et al USP 3,946,398</li> <li>1973 Stemme USP 3,747,120</li> <li>IJ03, IJ09, IJ10, IJ19, IJ23, IJ24, IJ25, IJ29, IJ30, IJ31, IJ33, IJ34, IJ35</li> </ul> |
| <b>Swivel</b>                         | The actuator swivels around a central pivot. This motion is suitable where there are opposite forces applied to opposite sides of the paddle, e.g. Lorenz force.               | <ul style="list-style-type: none"> <li>Allows operation where the net linear force on the paddle is zero</li> <li>Small chip area requirements</li> </ul> | <ul style="list-style-type: none"> <li>Inefficient coupling to the ink motion</li> </ul>                                                                                                                   | <ul style="list-style-type: none"> <li>IJ06</li> </ul>                                                                                                                                                    |
| <b>Straighten</b>                     | The actuator is normally bent, and straightens when energized.                                                                                                                 | <ul style="list-style-type: none"> <li>Can be used with shape memory alloys where the austenitic phase is planar</li> </ul>                               | <ul style="list-style-type: none"> <li>Requires careful balance of stresses to ensure that the quiescent bend is accurate</li> </ul>                                                                       | <ul style="list-style-type: none"> <li>IJ26, IJ32</li> </ul>                                                                                                                                              |

| ACTUATOR MOTION            |                                                                                                                                            |                                                                                                                                                                            |                                                                                                                                                                                                         |                                                                               |
|----------------------------|--------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------|
|                            | Description                                                                                                                                | Advantages                                                                                                                                                                 | Disadvantages                                                                                                                                                                                           | Examples                                                                      |
| <b>Double bend</b>         | The actuator bends in one direction when one element is energized, and bends the other way when another element is energized.              | <ul style="list-style-type: none"> <li>One actuator can be used to power two nozzles.</li> <li>Reduced chip size.</li> <li>Not sensitive to ambient temperature</li> </ul> | <ul style="list-style-type: none"> <li>Difficult to make the drops ejected by both bend directions identical.</li> <li>A small efficiency loss compared to equivalent single bend actuators.</li> </ul> | <ul style="list-style-type: none"> <li>IJ36, IJ37, IJ38</li> </ul>            |
| <b>Shear</b>               | Energizing the actuator causes a shear motion in the actuator material.                                                                    | <ul style="list-style-type: none"> <li>Can increase the effective travel of piezoelectric actuators</li> </ul>                                                             | <ul style="list-style-type: none"> <li>Not readily applicable to other actuator mechanisms</li> </ul>                                                                                                   | <ul style="list-style-type: none"> <li>1985 Fishbeck USP 4,584,590</li> </ul> |
| <b>Radial constriction</b> | The actuator squeezes an ink reservoir, forcing ink from a constricted nozzle.                                                             | <ul style="list-style-type: none"> <li>Relatively easy to fabricate single nozzles from glass tubing as macroscopic structures</li> </ul>                                  | <ul style="list-style-type: none"> <li>High force required</li> <li>Inefficient</li> <li>Difficult to integrate with VLSI processes</li> </ul>                                                          | <ul style="list-style-type: none"> <li>1970 Zoltan USP 3,683,212</li> </ul>   |
| <b>Coil / uncoil</b>       | A coiled actuator uncoils or coils more tightly. The motion of the free end of the actuator ejects the ink.                                | <ul style="list-style-type: none"> <li>Easy to fabricate as a planar VLSI process</li> <li>Small area required, therefore low cost</li> </ul>                              | <ul style="list-style-type: none"> <li>Difficult to fabricate for non-planar devices</li> <li>Poor out-of-plane stiffness</li> </ul>                                                                    | <ul style="list-style-type: none"> <li>IJ17, IJ21, IJ34, IJ35</li> </ul>      |
| <b>Bow</b>                 | The actuator bows (or buckles) in the middle when energized.                                                                               | <ul style="list-style-type: none"> <li>Can increase the speed of travel</li> <li>Mechanically rigid</li> </ul>                                                             | <ul style="list-style-type: none"> <li>Maximum travel is constrained</li> <li>High force required</li> </ul>                                                                                            | <ul style="list-style-type: none"> <li>IJ16, IJ18, IJ27</li> </ul>            |
| <b>Push-Pull</b>           | Two actuators control a shutter. One actuator pulls the shutter, and the other pushes it.                                                  | <ul style="list-style-type: none"> <li>The structure is pinned at both ends, so has a high out-of-plane rigidity</li> </ul>                                                | <ul style="list-style-type: none"> <li>Not readily suitable for ink jets which directly push the ink</li> </ul>                                                                                         | <ul style="list-style-type: none"> <li>IJ18</li> </ul>                        |
| <b>Curl inwards</b>        | A set of actuators curl inwards to reduce the volume of ink that they enclose.                                                             | <ul style="list-style-type: none"> <li>Good fluid flow to the region behind the actuator increases efficiency</li> </ul>                                                   | <ul style="list-style-type: none"> <li>Design complexity</li> </ul>                                                                                                                                     | <ul style="list-style-type: none"> <li>IJ20, IJ42</li> </ul>                  |
| <b>Curl outwards</b>       | A set of actuators curl outwards, pressurizing ink in a chamber surrounding the actuators, and expelling ink from a nozzle in the chamber. | <ul style="list-style-type: none"> <li>Relatively simple construction</li> </ul>                                                                                           | <ul style="list-style-type: none"> <li>Relatively large chip area</li> </ul>                                                                                                                            | <ul style="list-style-type: none"> <li>IJ43</li> </ul>                        |
| <b>Iris</b>                | Multiple vanes enclose a volume of ink. These simultaneously rotate, reducing the volume between the vanes.                                | <ul style="list-style-type: none"> <li>High efficiency</li> <li>Small chip area</li> </ul>                                                                                 | <ul style="list-style-type: none"> <li>High fabrication complexity</li> <li>Not suitable for pigmented inks</li> </ul>                                                                                  | <ul style="list-style-type: none"> <li>IJ22</li> </ul>                        |

| ACTUATOR MOTION           |                                                        |                                                                                                         |                                                                                                                                                                                                                                                         |                                                                                                                                     |
|---------------------------|--------------------------------------------------------|---------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------|
|                           | Description                                            | Advantages                                                                                              | Disadvantages                                                                                                                                                                                                                                           | Examples                                                                                                                            |
| <b>Acoustic vibration</b> | The actuator vibrates at a high frequency.             | <ul style="list-style-type: none"> <li>♦ The actuator can be physically distant from the ink</li> </ul> | <ul style="list-style-type: none"> <li>♦ Large area required for efficient operation at useful frequencies</li> <li>♦ Acoustic coupling and crosstalk</li> <li>♦ Complex drive circuitry</li> <li>♦ Poor control of drop volume and position</li> </ul> | <ul style="list-style-type: none"> <li>♦ 1993 Hadimioglu et al, EUP 550,192</li> <li>♦ 1993 Elrod et al, EUP 572,220</li> </ul>     |
| <b>None</b>               | In various ink jet designs the actuator does not move. | <ul style="list-style-type: none"> <li>♦ No moving parts</li> </ul>                                     | <ul style="list-style-type: none"> <li>♦ Various other tradeoffs are required to eliminate moving parts</li> </ul>                                                                                                                                      | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ Tone-jet</li> </ul> |

| NOZZLE REFILL METHOD                      |                                                                                                                                                                                                                                                                                                                                              |                                                                                                                                                                                      |                                                                                                                                                                                                                    |                                                                                                                                                                                          |
|-------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                           | Description                                                                                                                                                                                                                                                                                                                                  | Advantages                                                                                                                                                                           | Disadvantages                                                                                                                                                                                                      | Examples                                                                                                                                                                                 |
| <b>Surface tension</b>                    | This is the normal way that ink jets are refilled. After the actuator is energized, it typically returns rapidly to its normal position. This rapid return sucks in air through the nozzle opening. The ink surface tension at the nozzle then exerts a small force restoring the meniscus to a minimum area. This force refills the nozzle. | <ul style="list-style-type: none"> <li>♦ Fabrication simplicity</li> <li>♦ Operational simplicity</li> </ul>                                                                         | <ul style="list-style-type: none"> <li>♦ Low speed</li> <li>♦ Surface tension force relatively small compared to actuator force</li> <li>♦ Long refill time usually dominates the total repetition rate</li> </ul> | <ul style="list-style-type: none"> <li>♦ Thermal ink jet</li> <li>♦ Piezoelectric ink jet</li> <li>♦ IJ01-IJ07, IJ10-IJ14, IJ16, IJ20, IJ22-IJ45</li> </ul>                              |
| <b>Shuttered oscillating ink pressure</b> | Ink to the nozzle chamber is provided at a pressure that oscillates at twice the drop ejection frequency. When a drop is to be ejected, the shutter is opened for 3 half cycles: drop ejection, actuator return, and refill. The shutter is then closed to prevent the nozzle chamber emptying during the next negative pressure cycle.      | <ul style="list-style-type: none"> <li>♦ High speed</li> <li>♦ Low actuator energy, as the actuator need only open or close the shutter, instead of ejecting the ink drop</li> </ul> | <ul style="list-style-type: none"> <li>♦ Requires common ink pressure oscillator</li> <li>♦ May not be suitable for pigmented inks</li> </ul>                                                                      | <ul style="list-style-type: none"> <li>♦ IJ08, IJ13, IJ15, IJ17, IJ18, IJ19, IJ21</li> </ul>                                                                                             |
| <b>Refill actuator</b>                    | After the main actuator has ejected a drop a second (refill) actuator is energized. The refill actuator pushes ink into the nozzle chamber. The refill actuator returns slowly, to prevent its return from emptying the chamber again.                                                                                                       | <ul style="list-style-type: none"> <li>♦ High speed, as the nozzle is actively refilled</li> </ul>                                                                                   | <ul style="list-style-type: none"> <li>♦ Requires two independent actuators per nozzle</li> </ul>                                                                                                                  | <ul style="list-style-type: none"> <li>♦ IJ09</li> </ul>                                                                                                                                 |
| <b>Positive ink pressure</b>              | The ink is held a slight positive pressure. After the ink drop is ejected, the nozzle chamber fills quickly as surface tension and ink pressure both operate to refill the nozzle.                                                                                                                                                           | <ul style="list-style-type: none"> <li>♦ High refill rate, therefore a high drop repetition rate is possible</li> </ul>                                                              | <ul style="list-style-type: none"> <li>♦ Surface spill must be prevented</li> <li>♦ Highly hydrophobic print head surfaces are required</li> </ul>                                                                 | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ Alternative for:, IJ01-IJ07, IJ10-IJ14, IJ16, IJ20, IJ22-IJ45</li> </ul> |

| METHOD OF RESTRICTING BACK-FLOW THROUGH INLET |                                                                                                                                                                                                                                                                                                                                |                                                                                                                                                 |                                                                                                                                                                                                                                   |                                                                                                                                                                                                                                              |
|-----------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                               | Description                                                                                                                                                                                                                                                                                                                    | Advantages                                                                                                                                      | Disadvantages                                                                                                                                                                                                                     | Examples                                                                                                                                                                                                                                     |
| <b>Long inlet channel</b>                     | The ink inlet channel to the nozzle chamber is made long and relatively narrow, relying on viscous drag to reduce inlet back-flow.                                                                                                                                                                                             | <ul style="list-style-type: none"> <li>◆ Design simplicity</li> <li>◆ Operational simplicity</li> <li>◆ Reduces crosstalk</li> </ul>            | <ul style="list-style-type: none"> <li>◆ Restricts refill rate</li> <li>◆ May result in a relatively large chip area</li> <li>◆ Only partially effective</li> </ul>                                                               | <ul style="list-style-type: none"> <li>◆ Thermal ink jet</li> <li>◆ Piezoelectric ink jet</li> <li>◆ IJ42, IJ43</li> </ul>                                                                                                                   |
| <b>Positive ink pressure</b>                  | The ink is under a positive pressure, so that in the quiescent state some of the ink drop already protrudes from the nozzle. This reduces the pressure in the nozzle chamber which is required to eject a certain volume of ink. The reduction in chamber pressure results in a reduction in ink pushed out through the inlet. | <ul style="list-style-type: none"> <li>◆ Drop selection and separation forces can be reduced</li> <li>◆ Fast refill time</li> </ul>             | <ul style="list-style-type: none"> <li>◆ Requires a method (such as a nozzle rim or effective hydrophobizing, or both) to prevent flooding of the ejection surface of the print head.</li> </ul>                                  | <ul style="list-style-type: none"> <li>◆ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>◆ Possible operation of the following: IJ01-IJ07, IJ09- IJ12, IJ14, IJ16, IJ20, IJ22, , IJ23-IJ34, IJ36- IJ41, IJ44</li> </ul> |
| <b>Baffle</b>                                 | One or more baffles are placed in the inlet ink flow. When the actuator is energized, the rapid ink movement creates eddies which restrict the flow through the inlet. The slower refill process is unrestricted, and does not result in eddies.                                                                               | <ul style="list-style-type: none"> <li>◆ The refill rate is not as restricted as the long inlet method.</li> <li>◆ Reduces crosstalk</li> </ul> | <ul style="list-style-type: none"> <li>◆ Design complexity</li> <li>◆ May increase fabrication complexity (e.g. Tektronix hot melt Piezoelectric print heads).</li> </ul>                                                         | <ul style="list-style-type: none"> <li>◆ HP Thermal Ink Jet</li> <li>◆ Tektronix piezoelectric ink jet</li> </ul>                                                                                                                            |
| <b>Flexible flap restricts inlet</b>          | In this method recently disclosed by Canon, the expanding actuator (bubble) pushes on a flexible flap that restricts the inlet.                                                                                                                                                                                                | <ul style="list-style-type: none"> <li>◆ Significantly reduces back-flow for edge-shooter thermal ink jet devices</li> </ul>                    | <ul style="list-style-type: none"> <li>◆ Not applicable to most ink jet configurations</li> <li>◆ Increased fabrication complexity</li> <li>◆ Inelastic deformation of polymer flap results in creep over extended use</li> </ul> | <ul style="list-style-type: none"> <li>◆ Canon</li> </ul>                                                                                                                                                                                    |

| METHOD OF RESTRICTING BACK-FLOW THROUGH INLET              |                                                                                                                                                                                                           |                                                                                                                                                                     |                                                                                                                                                                     |                                                                                                                                                                                        |
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|                                                            | Description                                                                                                                                                                                               | Advantages                                                                                                                                                          | Disadvantages                                                                                                                                                       | Examples                                                                                                                                                                               |
| <b>Inlet filter</b>                                        | A filter is located between the ink inlet and the nozzle chamber. The filter has a multitude of small holes or slots, restricting ink flow. The filter also removes particles which may block the nozzle. | <ul style="list-style-type: none"> <li>◆ Additional advantage of ink filtration</li> <li>◆ Ink filter may be fabricated with no additional process steps</li> </ul> | <ul style="list-style-type: none"> <li>◆ Restricts refill rate</li> <li>◆ May result in complex construction</li> </ul>                                             | <ul style="list-style-type: none"> <li>◆ IJ04, IJ12, IJ24, IJ27, IJ29, IJ30</li> </ul>                                                                                                 |
| <b>Small inlet compared to nozzle</b>                      | The ink inlet channel to the nozzle chamber has a substantially smaller cross section than that of the nozzle, resulting in easier ink egress out of the nozzle than out of the inlet.                    | <ul style="list-style-type: none"> <li>◆ Design simplicity</li> </ul>                                                                                               | <ul style="list-style-type: none"> <li>◆ Restricts refill rate</li> <li>◆ May result in a relatively large chip area</li> <li>◆ Only partially effective</li> </ul> | <ul style="list-style-type: none"> <li>◆ IJ02, IJ37, IJ44</li> </ul>                                                                                                                   |
| <b>Inlet shutter</b>                                       | A secondary actuator controls the position of a shutter, closing off the ink inlet when the main actuator is energized.                                                                                   | <ul style="list-style-type: none"> <li>◆ Increases speed of the ink-jet print head operation</li> </ul>                                                             | <ul style="list-style-type: none"> <li>◆ Requires separate refill actuator and drive circuit</li> </ul>                                                             | <ul style="list-style-type: none"> <li>◆ IJ09</li> </ul>                                                                                                                               |
| <b>The inlet is located behind the ink-pushing surface</b> | The method avoids the problem of inlet back-flow by arranging the ink-pushing surface of the actuator between the inlet and the nozzle.                                                                   | <ul style="list-style-type: none"> <li>◆ Back-flow problem is eliminated</li> </ul>                                                                                 | <ul style="list-style-type: none"> <li>◆ Requires careful design to minimize the negative pressure behind the paddle</li> </ul>                                     | <ul style="list-style-type: none"> <li>◆ IJ01, IJ03, IJ05, IJ06, IJ07, IJ10, IJ11, IJ14, IJ16, IJ22, IJ23, IJ25, IJ28, IJ31, IJ32, IJ33, IJ34, IJ35, IJ36, IJ39, IJ40, IJ41</li> </ul> |
| <b>Part of the actuator moves to shut off the inlet</b>    | The actuator and a wall of the ink chamber are arranged so that the motion of the actuator closes off the inlet.                                                                                          | <ul style="list-style-type: none"> <li>◆ Significant reductions in back-flow can be achieved</li> <li>◆ Compact designs possible</li> </ul>                         | <ul style="list-style-type: none"> <li>◆ Small increase in fabrication complexity</li> </ul>                                                                        | <ul style="list-style-type: none"> <li>◆ IJ07, IJ20, IJ26, IJ38</li> </ul>                                                                                                             |
| <b>Nozzle actuator does not result in ink back-flow</b>    | In some configurations of ink jet, there is no expansion or movement of an actuator which may cause ink back-flow through the inlet.                                                                      | <ul style="list-style-type: none"> <li>◆ Ink back-flow problem is eliminated</li> </ul>                                                                             | <ul style="list-style-type: none"> <li>◆ None related to ink back-flow on actuation</li> </ul>                                                                      | <ul style="list-style-type: none"> <li>◆ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>◆ Valve-jet</li> <li>◆ Tone-jet</li> </ul>                               |

| NOZZLE CLEARING METHOD                     |                                                                                                                                                                                                                                                                                            |                                                                                                                                                                                 |                                                                                                                                                |                                                                                                                                                                                                                                                                                                                    |
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|                                            | Description                                                                                                                                                                                                                                                                                | Advantages                                                                                                                                                                      | Disadvantages                                                                                                                                  | Examples                                                                                                                                                                                                                                                                                                           |
| <b>Normal nozzle firing</b>                | <p>All of the nozzles are fired periodically, before the ink has a chance to dry. When not in use the nozzles are sealed (capped) against air.</p> <p>The nozzle firing is usually performed during a special clearing cycle, after first moving the print head to a cleaning station.</p> | <ul style="list-style-type: none"> <li>◆ No added complexity on the print head</li> </ul>                                                                                       | <ul style="list-style-type: none"> <li>◆ May not be sufficient to displace dried ink</li> </ul>                                                | <ul style="list-style-type: none"> <li>◆ Most ink jet systems</li> <li>◆ IJ01, IJ02, IJ03, IJ04, IJ05, IJ06, IJ07, IJ09, IJ10, IJ11, IJ12, IJ14, IJ16, IJ20, IJ22, IJ23, IJ24, IJ25, IJ26, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ36, IJ37, IJ38, IJ39, IJ40,, IJ41, IJ42, IJ43, IJ44,, IJ45</li> </ul> |
| <b>Extra power to ink heater</b>           | <p>In systems which heat the ink, but do not boil it under normal situations, nozzle clearing can be achieved by over-powering the heater and boiling ink at the nozzle.</p>                                                                                                               | <ul style="list-style-type: none"> <li>◆ Can be highly effective if the heater is adjacent to the nozzle</li> </ul>                                                             | <ul style="list-style-type: none"> <li>◆ Requires higher drive voltage for clearing</li> <li>◆ May require larger drive transistors</li> </ul> | <ul style="list-style-type: none"> <li>◆ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                                                                                                                                                    |
| <b>Rapid succession of actuator pulses</b> | <p>The actuator is fired in rapid succession. In some configurations, this may cause heat build-up at the nozzle which boils the ink, clearing the nozzle. In other situations, it may cause sufficient vibrations to dislodge clogged nozzles.</p>                                        | <ul style="list-style-type: none"> <li>◆ Does not require extra drive circuits on the print head</li> <li>◆ Can be readily controlled and initiated by digital logic</li> </ul> | <ul style="list-style-type: none"> <li>◆ Effectiveness depends substantially upon the configuration of the ink jet nozzle</li> </ul>           | <ul style="list-style-type: none"> <li>◆ May be used with: IJ01, IJ02, IJ03, IJ04, IJ05, IJ06, IJ07, IJ09, IJ10, IJ11, IJ14, IJ16, IJ20, IJ22, IJ23, IJ24, IJ25, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ36, IJ37, IJ38, IJ39, IJ40, IJ41, IJ42, IJ43, IJ44, IJ45</li> </ul>                             |
| <b>Extra power to ink pushing actuator</b> | <p>Where an actuator is not normally driven to the limit of its motion, nozzle clearing may be assisted by providing an enhanced drive signal to the actuator.</p>                                                                                                                         | <ul style="list-style-type: none"> <li>◆ A simple solution where applicable</li> </ul>                                                                                          | <ul style="list-style-type: none"> <li>◆ Not suitable where there is a hard limit to actuator movement</li> </ul>                              | <ul style="list-style-type: none"> <li>◆ May be used with: IJ03, IJ09, IJ16, IJ20, IJ23, IJ24, IJ25, IJ27, IJ29, IJ30, IJ31, IJ32, IJ39, IJ40, IJ41, IJ42, IJ43, IJ44, IJ45</li> </ul>                                                                                                                             |

| NOZZLE CLEARING METHOD             |                                                                                                                                                                                                                                                                      |                                                                                                                                                                                                            |                                                                                                                                                                                                                                  |                                                                                                                 |
|------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------|
|                                    | Description                                                                                                                                                                                                                                                          | Advantages                                                                                                                                                                                                 | Disadvantages                                                                                                                                                                                                                    | Examples                                                                                                        |
| <b>Acoustic resonance</b>          | An ultrasonic wave is applied to the ink chamber. This wave is of an appropriate amplitude and frequency to cause sufficient force at the nozzle to clear blockages. This is easiest to achieve if the ultrasonic wave is at a resonant frequency of the ink cavity. | <ul style="list-style-type: none"> <li>♦ A high nozzle clearing capability can be achieved</li> <li>♦ May be implemented at very low cost in systems which already include acoustic actuators</li> </ul>   | <ul style="list-style-type: none"> <li>♦ High implementation cost if system does not already include an acoustic actuator</li> </ul>                                                                                             | <ul style="list-style-type: none"> <li>♦ IJ08, IJ13, IJ15, IJ17, IJ18, IJ19, IJ21</li> </ul>                    |
| <b>Nozzle clearing plate</b>       | A microfabricated plate is pushed against the nozzles. The plate has a post for every nozzle. A post moves through each nozzle, displacing dried ink.                                                                                                                | <ul style="list-style-type: none"> <li>♦ Can clear severely clogged nozzles</li> </ul>                                                                                                                     | <ul style="list-style-type: none"> <li>♦ Accurate mechanical alignment is required</li> <li>♦ Moving parts are required</li> <li>♦ There is risk of damage to the nozzles</li> <li>♦ Accurate fabrication is required</li> </ul> | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul> |
| <b>Ink pressure pulse</b>          | The pressure of the ink is temporarily increased so that ink streams from all of the nozzles. This may be used in conjunction with actuator energizing.                                                                                                              | <ul style="list-style-type: none"> <li>♦ May be effective where other methods cannot be used</li> </ul>                                                                                                    | <ul style="list-style-type: none"> <li>♦ Requires pressure pump or other pressure actuator</li> <li>♦ Expensive</li> <li>♦ Wasteful of ink</li> </ul>                                                                            | <ul style="list-style-type: none"> <li>♦ May be used with all IJ series ink jets</li> </ul>                     |
| <b>Print head wiper</b>            | A flexible 'blade' is wiped across the print head surface. The blade is usually fabricated from a flexible polymer, e.g. rubber or synthetic elastomer.                                                                                                              | <ul style="list-style-type: none"> <li>♦ Effective for planar print head surfaces</li> <li>♦ Low cost</li> </ul>                                                                                           | <ul style="list-style-type: none"> <li>♦ Difficult to use if print head surface is non-planar or very fragile</li> <li>♦ Requires mechanical parts</li> <li>♦ Blade can wear out in high volume print systems</li> </ul>         | <ul style="list-style-type: none"> <li>♦ Many ink jet systems</li> </ul>                                        |
| <b>Separate ink boiling heater</b> | A separate heater is provided at the nozzle although the normal drop ejection mechanism does not require it. The heaters do not require individual drive circuits, as many nozzles can be cleared simultaneously, and no imaging is required.                        | <ul style="list-style-type: none"> <li>♦ Can be effective where other nozzle clearing methods cannot be used</li> <li>♦ Can be implemented at no additional cost in some ink jet configurations</li> </ul> | <ul style="list-style-type: none"> <li>♦ Fabrication complexity</li> </ul>                                                                                                                                                       | <ul style="list-style-type: none"> <li>♦ Can be used with many IJ series ink jets</li> </ul>                    |

| NOZZLE CLEARING METHOD                                                      |                                                                                                                                                                                                       |                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                                             |
|-----------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                                             | Description                                                                                                                                                                                           | Advantages                                                                                                                                                                                                      | Disadvantages                                                                                                                                                                                                                                            | Examples                                                                                                                                                                                                                                                                                    |
| NOZZLE PLATE CONSTRUCTION                                                   |                                                                                                                                                                                                       |                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                                             |
|                                                                             | Description                                                                                                                                                                                           | Advantages                                                                                                                                                                                                      | Disadvantages                                                                                                                                                                                                                                            | Examples                                                                                                                                                                                                                                                                                    |
| <b>Electro-formed nickel</b>                                                | A nozzle plate is separately fabricated from electroformed nickel, and bonded to the print head chip.                                                                                                 | <ul style="list-style-type: none"> <li>♦ Fabrication simplicity</li> </ul>                                                                                                                                      | <ul style="list-style-type: none"> <li>♦ High temperatures and pressures are required to bond nozzle plate</li> <li>♦ Minimum thickness constraints</li> <li>♦ Differential thermal expansion</li> </ul>                                                 | <ul style="list-style-type: none"> <li>♦ Hewlett Packard Thermal Ink jet</li> </ul>                                                                                                                                                                                                         |
| <b>Laser ablated or drilled polymer</b>                                     | Individual nozzle holes are ablated by an intense UV laser in a nozzle plate, which is typically a polymer such as polyimide or polysulphone                                                          | <ul style="list-style-type: none"> <li>♦ No masks required</li> <li>♦ Can be quite fast</li> <li>♦ Some control over nozzle profile is possible</li> <li>♦ Equipment required is relatively low cost</li> </ul> | <ul style="list-style-type: none"> <li>♦ Each hole must be individually formed</li> <li>♦ Special equipment required</li> <li>♦ Slow where there are many thousands of nozzles per print head</li> <li>♦ May produce thin burrs at exit holes</li> </ul> | <ul style="list-style-type: none"> <li>♦ Canon Bubblejet</li> <li>♦ 1988 Sercel et al., SPIE, Vol. 998 Excimer Beam Applications, pp. 76-83</li> <li>♦ 1993 Watanabe et al., USP 5,208,604</li> </ul>                                                                                       |
| <b>Silicon micro-machined</b>                                               | A separate nozzle plate is micromachined from single crystal silicon, and bonded to the print head wafer.                                                                                             | <ul style="list-style-type: none"> <li>♦ High accuracy is attainable</li> </ul>                                                                                                                                 | <ul style="list-style-type: none"> <li>♦ Two part construction</li> <li>♦ High cost</li> <li>♦ Requires precision alignment</li> <li>♦ Nozzles may be clogged by adhesive</li> </ul>                                                                     | <ul style="list-style-type: none"> <li>♦ K. Bean, IEEE Transactions on Electron Devices, Vol. ED-25, No. 10, 1978, pp 1185-1195</li> <li>♦ Xerox 1990 Hawkins et al., USP 4,899,181</li> </ul>                                                                                              |
| <b>Glass capillaries</b>                                                    | Fine glass capillaries are drawn from glass tubing. This method has been used for making individual nozzles, but is difficult to use for bulk manufacturing of print heads with thousands of nozzles. | <ul style="list-style-type: none"> <li>♦ No expensive equipment required</li> <li>♦ Simple to make single nozzles</li> </ul>                                                                                    | <ul style="list-style-type: none"> <li>♦ Very small nozzle sizes are difficult to form</li> <li>♦ Not suited for mass production</li> </ul>                                                                                                              | <ul style="list-style-type: none"> <li>♦ 1970 Zoltan USP 3,683,212</li> </ul>                                                                                                                                                                                                               |
| <b>Monolithic, surface micro-machined using VLSI lithographic processes</b> | The nozzle plate is deposited as a layer using standard VLSI deposition techniques. Nozzles are etched in the nozzle plate using VLSI lithography and etching.                                        | <ul style="list-style-type: none"> <li>♦ High accuracy (&lt;1 <math>\mu\text{m}</math>)</li> <li>♦ Monolithic</li> <li>♦ Low cost</li> <li>♦ Existing processes can be used</li> </ul>                          | <ul style="list-style-type: none"> <li>♦ Requires sacrificial layer under the nozzle plate to form the nozzle chamber</li> <li>♦ Surface may be fragile to the touch</li> </ul>                                                                          | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ IJ01, IJ02, IJ04, IJ11, IJ12, IJ17, IJ18, IJ20, IJ22, IJ24, IJ27, IJ28, IJ29, IJ30, IJ31, IJ32, IJ33, IJ34, IJ36, IJ37, IJ38, IJ39, IJ40, IJ41, IJ42, IJ43, IJ44</li> </ul> |

| NOZZLE CLEARING METHOD                           |                                                                                                                                                                                                         |                                                                                                                                                                                    |                                                                                                                                 |                                                                                                                                                                                |
|--------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                  | Description                                                                                                                                                                                             | Advantages                                                                                                                                                                         | Disadvantages                                                                                                                   | Examples                                                                                                                                                                       |
| <b>Monolithic, etched through substrate</b>      | The nozzle plate is a buried etch stop in the wafer. Nozzle chambers are etched in the front of the wafer, and the wafer is thinned from the back side. Nozzles are then etched in the etch stop layer. | <ul style="list-style-type: none"> <li>◆ High accuracy (<math>&lt;1\ \mu\text{m}</math>)</li> <li>◆ Monolithic</li> <li>◆ Low cost</li> <li>◆ No differential expansion</li> </ul> | <ul style="list-style-type: none"> <li>◆ Requires long etch times</li> <li>◆ Requires a support wafer</li> </ul>                | <ul style="list-style-type: none"> <li>◆ IJ03, IJ05, IJ06, IJ07, IJ08, IJ09, IJ10, IJ13, IJ14, IJ15, IJ16, IJ19, IJ21, IJ23, IJ25, IJ26</li> </ul>                             |
| <b>No nozzle plate</b>                           | Various methods have been tried to eliminate the nozzles entirely, to prevent nozzle clogging. These include thermal bubble mechanisms and acoustic lens mechanisms                                     | <ul style="list-style-type: none"> <li>◆ No nozzles to become clogged</li> </ul>                                                                                                   | <ul style="list-style-type: none"> <li>◆ Difficult to control drop position accurately</li> <li>◆ Crosstalk problems</li> </ul> | <ul style="list-style-type: none"> <li>◆ Ricoh 1995 Sekiya et al USP 5,412,413</li> <li>◆ 1993 Hadimioglu et al EUP 550,192</li> <li>◆ 1993 Elrod et al EUP 572,220</li> </ul> |
| <b>Trough</b>                                    | Each drop ejector has a trough through which a paddle moves. There is no nozzle plate.                                                                                                                  | <ul style="list-style-type: none"> <li>◆ Reduced manufacturing complexity</li> <li>◆ Monolithic</li> </ul>                                                                         | <ul style="list-style-type: none"> <li>◆ Drop firing direction is sensitive to wicking.</li> </ul>                              | <ul style="list-style-type: none"> <li>◆ IJ35</li> </ul>                                                                                                                       |
| <b>Nozzle slit instead of individual nozzles</b> | The elimination of nozzle holes and replacement by a slit encompassing many actuator positions reduces nozzle clogging, but increases crosstalk due to ink surface waves                                | <ul style="list-style-type: none"> <li>◆ No nozzles to become clogged</li> </ul>                                                                                                   | <ul style="list-style-type: none"> <li>◆ Difficult to control drop position accurately</li> <li>◆ Crosstalk problems</li> </ul> | <ul style="list-style-type: none"> <li>◆ 1989 Saito et al USP 4,799,068</li> </ul>                                                                                             |

| DROP EJECTION DIRECTION         |                                                                                                                              |                                                                                                                                                                                                                           |                                                                                                                                                                                      |                                                                                                                                                                                             |
|---------------------------------|------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                 | Description                                                                                                                  | Advantages                                                                                                                                                                                                                | Disadvantages                                                                                                                                                                        | Examples                                                                                                                                                                                    |
| <b>Edge ('edge shooter')</b>    | Ink flow is along the surface of the chip, and ink drops are ejected from the chip edge.                                     | <ul style="list-style-type: none"> <li>◆ Simple construction</li> <li>◆ No silicon etching required</li> <li>◆ Good heat sinking via substrate</li> <li>◆ Mechanically strong</li> <li>◆ Ease of chip handling</li> </ul> | <ul style="list-style-type: none"> <li>◆ Nozzles limited to edge</li> <li>◆ High resolution is difficult</li> <li>◆ Fast color printing requires one print head per color</li> </ul> | <ul style="list-style-type: none"> <li>◆ Canon Bubblejet 1979 Endo et al GB patent 2,007,162</li> <li>◆ Xerox heater-in-pit 1990 Hawkins et al USP 4,899,181</li> <li>◆ Tone-jet</li> </ul> |
| <b>Surface ('roof shooter')</b> | Ink flow is along the surface of the chip, and ink drops are ejected from the chip surface, normal to the plane of the chip. | <ul style="list-style-type: none"> <li>◆ No bulk silicon etching required</li> <li>◆ Silicon can make an effective heat sink</li> <li>◆ Mechanical strength</li> </ul>                                                    | <ul style="list-style-type: none"> <li>◆ Maximum ink flow is severely restricted</li> </ul>                                                                                          | <ul style="list-style-type: none"> <li>◆ Hewlett-Packard TIJ 1982 Vaught et al USP 4,490,728</li> <li>◆ IJ02, IJ11, IJ12, IJ20, IJ22</li> </ul>                                             |

| DROP EJECTION DIRECTION                          |                                                                                                                   |                                                                                                                                                                                         |                                                                                                                                                                                                                               |                                                                                                                                                              |
|--------------------------------------------------|-------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                  | Description                                                                                                       | Advantages                                                                                                                                                                              | Disadvantages                                                                                                                                                                                                                 | Examples                                                                                                                                                     |
| <b>Through chip, forward</b><br>(‘up shooter’)   | Ink flow is through the chip, and ink drops are ejected from the front surface of the chip.                       | <ul style="list-style-type: none"> <li>♦ High ink flow</li> <li>♦ Suitable for pagewidth print heads</li> <li>♦ High nozzle packing density therefore low manufacturing cost</li> </ul> | <ul style="list-style-type: none"> <li>♦ Requires bulk silicon etching</li> </ul>                                                                                                                                             | <ul style="list-style-type: none"> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ IJ04, IJ17, IJ18, IJ24, IJ27-IJ45</li> </ul> |
| <b>Through chip, reverse</b><br>(‘down shooter’) | Ink flow is through the chip, and ink drops are ejected from the rear surface of the chip.                        | <ul style="list-style-type: none"> <li>♦ High ink flow</li> <li>♦ Suitable for pagewidth print heads</li> <li>♦ High nozzle packing density therefore low manufacturing cost</li> </ul> | <ul style="list-style-type: none"> <li>♦ Requires wafer thinning</li> <li>♦ Requires special handling during manufacture</li> </ul>                                                                                           | <ul style="list-style-type: none"> <li>♦ IJ01, IJ03, IJ05, IJ06, IJ07, IJ08, IJ09, IJ10, IJ13, IJ14, IJ15, IJ16, IJ19, IJ21, IJ23, IJ25, IJ26</li> </ul>     |
| <b>Through actuator</b>                          | Ink flow is through the actuator, which is not fabricated as part of the same substrate as the drive transistors. | <ul style="list-style-type: none"> <li>♦ Suitable for piezoelectric print heads</li> </ul>                                                                                              | <ul style="list-style-type: none"> <li>♦ Pagewidth print heads require several thousand connections to drive circuits</li> <li>♦ Cannot be manufactured in standard CMOS fabs</li> <li>♦ Complex assembly required</li> </ul> | <ul style="list-style-type: none"> <li>♦ Epson Stylus</li> <li>♦ Tektronix hot melt piezoelectric ink jets</li> </ul>                                        |

| INK TYPE                                        |                                                                                                                                                                                                                                                                     |                                                                                                                                                                                                                                                                                          |                                                                                                                                                                                                                                                                                                           |                                                                                                                                                                                                                                                             |
|-------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
|                                                 | Description                                                                                                                                                                                                                                                         | Advantages                                                                                                                                                                                                                                                                               | Disadvantages                                                                                                                                                                                                                                                                                             | Examples                                                                                                                                                                                                                                                    |
| <b>Aqueous, dye</b>                             | Water based ink which typically contains: water, dye, surfactant, humectant, and biocide.<br>Modern ink dyes have high water-fastness, light fastness                                                                                                               | <ul style="list-style-type: none"> <li>♦ Environmentally friendly</li> <li>♦ No odor</li> </ul>                                                                                                                                                                                          | <ul style="list-style-type: none"> <li>♦ Slow drying</li> <li>♦ Corrosive</li> <li>♦ Bleeds on paper</li> <li>♦ May strikethrough</li> <li>♦ Cockles paper</li> </ul>                                                                                                                                     | <ul style="list-style-type: none"> <li>♦ Most existing ink jets</li> <li>♦ All IJ series ink jets</li> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> </ul>                                                                         |
| <b>Aqueous, pigment</b>                         | Water based ink which typically contains: water, pigment, surfactant, humectant, and biocide.<br>Pigments have an advantage in reduced bleed, wicking and strikethrough.                                                                                            | <ul style="list-style-type: none"> <li>♦ Environmentally friendly</li> <li>♦ No odor</li> <li>♦ Reduced bleed</li> <li>♦ Reduced wicking</li> <li>♦ Reduced strikethrough</li> </ul>                                                                                                     | <ul style="list-style-type: none"> <li>♦ Slow drying</li> <li>♦ Corrosive</li> <li>♦ Pigment may clog nozzles</li> <li>♦ Pigment may clog actuator mechanisms</li> <li>♦ Cockles paper</li> </ul>                                                                                                         | <ul style="list-style-type: none"> <li>♦ IJ02, IJ04, IJ21, IJ26, IJ27, IJ30</li> <li>♦ Silverbrook, EP 0771 658 A2 and related patent applications</li> <li>♦ Piezoelectric ink-jets</li> <li>♦ Thermal ink jets (with significant restrictions)</li> </ul> |
| <b>Methyl Ethyl Ketone (MEK)</b>                | MEK is a highly volatile solvent used for industrial printing on difficult surfaces such as aluminum cans.                                                                                                                                                          | <ul style="list-style-type: none"> <li>♦ Very fast drying</li> <li>♦ Prints on various substrates such as metals and plastics</li> </ul>                                                                                                                                                 | <ul style="list-style-type: none"> <li>♦ Odorous</li> <li>♦ Flammable</li> </ul>                                                                                                                                                                                                                          | <ul style="list-style-type: none"> <li>♦ All IJ series ink jets</li> </ul>                                                                                                                                                                                  |
| <b>Alcohol (ethanol, 2-butanol, and others)</b> | Alcohol based inks can be used where the printer must operate at temperatures below the freezing point of water. An example of this is in-camera consumer photographic printing.                                                                                    | <ul style="list-style-type: none"> <li>♦ Fast drying</li> <li>♦ Operates at sub-freezing temperatures</li> <li>♦ Reduced paper cockle</li> <li>♦ Low cost</li> </ul>                                                                                                                     | <ul style="list-style-type: none"> <li>♦ Slight odor</li> <li>♦ Flammable</li> </ul>                                                                                                                                                                                                                      | <ul style="list-style-type: none"> <li>♦ All IJ series ink jets</li> </ul>                                                                                                                                                                                  |
| <b>Phase change (hot melt)</b>                  | The ink is solid at room temperature, and is melted in the print head before jetting. Hot melt inks are usually wax based, with a melting point around 80 °C. After jetting the ink freezes almost instantly upon contacting the print medium or a transfer roller. | <ul style="list-style-type: none"> <li>♦ No drying time-ink instantly freezes on the print medium</li> <li>♦ Almost any print medium can be used</li> <li>♦ No paper cockle occurs</li> <li>♦ No wicking occurs</li> <li>♦ No bleed occurs</li> <li>♦ No strikethrough occurs</li> </ul> | <ul style="list-style-type: none"> <li>♦ High viscosity</li> <li>♦ Printed ink typically has a 'waxy' feel</li> <li>♦ Printed pages may 'block'</li> <li>♦ Ink temperature may be above the curie point of permanent magnets</li> <li>♦ Ink heaters consume power</li> <li>♦ Long warm-up time</li> </ul> | <ul style="list-style-type: none"> <li>♦ Tektronix hot melt piezoelectric ink jets</li> <li>♦ 1989 Nowak USP 4,820,346</li> <li>♦ All IJ series ink jets</li> </ul>                                                                                         |

| INK TYPE              |                                                                                                                                                                                                     |                                                                                                                                                                                                                 |                                                                                                                                                                                                                                                                     |                                                                            |
|-----------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------|
|                       | Description                                                                                                                                                                                         | Advantages                                                                                                                                                                                                      | Disadvantages                                                                                                                                                                                                                                                       | Examples                                                                   |
| <b>Oil</b>            | Oil based inks are extensively used in offset printing. They have advantages in improved characteristics on paper (especially no wicking or cockle). Oil soluble dyes and pigments are required.    | <ul style="list-style-type: none"> <li>◆ High solubility medium for some dyes</li> <li>◆ Does not cockle paper</li> <li>◆ Does not wick through paper</li> </ul>                                                | <ul style="list-style-type: none"> <li>◆ High viscosity: this is a significant limitation for use in ink jets, which usually require a low viscosity. Some short chain and multi-branched oils have a sufficiently low viscosity.</li> <li>◆ Slow drying</li> </ul> | <ul style="list-style-type: none"> <li>◆ All IJ series ink jets</li> </ul> |
| <b>Micro-emulsion</b> | A microemulsion is a stable, self forming emulsion of oil, water, and surfactant. The characteristic drop size is less than 100 nm, and is determined by the preferred curvature of the surfactant. | <ul style="list-style-type: none"> <li>◆ Stops ink bleed</li> <li>◆ High dye solubility</li> <li>◆ Water, oil, and amphiphilic soluble dyes can be used</li> <li>◆ Can stabilize pigment suspensions</li> </ul> | <ul style="list-style-type: none"> <li>◆ Viscosity higher than water</li> <li>◆ Cost is slightly higher than water based ink</li> <li>◆ High surfactant concentration required (around 5%)</li> </ul>                                                               | <ul style="list-style-type: none"> <li>◆ All IJ series ink jets</li> </ul> |

**CLAIMS**

1. A printhead comprising:
  - a substrate including a plurality of nozzles for ejecting ink droplets onto a print medium, each nozzle having a nozzle aperture defined in an ink ejection surface of the substrate; and
  - a plurality of formations on the ink ejection surface, the surface formations being configured to isolate each nozzle from at least one adjacent nozzle, wherein the surface formations are configured in a plurality of individual caps spaced apart across the ink ejection surface, each cap comprising a roof spaced apart from a respective nozzle aperture and sidewalls extending from a perimeter region of the roof to form a seal with the ink ejection surface, the roof having a roof opening aligned with the respective nozzle aperture, thereby allowing ejected ink droplets to pass therethrough onto the print medium.
2. The printhead of claim 1, wherein the surface formations each have a hydrophobic surface.
3. The printhead of claim 1, which is a pagewidth inkjet printhead.
4. The printhead of claim 1, wherein the printhead has a nozzle density sufficient to print at up to 1600 dpi.
5. A printer comprising the printhead according to claim 1.
6. A method of printing from the printhead of claim 1, whilst minimizing cross-contamination of ink between adjacent nozzles, the method comprising the steps of:
  - (a) providing a printhead according to claim 1; and
  - (b) printing onto a print medium using said printhead.

7. A method of fabricating the printhead according to claim 1 having isolated nozzles, the method comprising the steps of:

- (a) providing a substrate, the substrate including a plurality of nozzles for ejecting ink droplets onto a print medium, each nozzle having a nozzle aperture defined in an ink ejection surface of the substrate;
- (b) depositing a layer of photoresist over the ink ejection surface;
- (c) defining recesses in the photoresist, each recess revealing a portion of the ink ejection surface surrounding a respective nozzle aperture;
- (d) depositing a roof material over the photoresist and into the recesses;
- (e) etching the roof material to define an individual nozzle cap around each nozzle aperture, each nozzle cap having an opening defined in a roof and sidewalls extending from the roof to the ink ejection surface; and
- (f) removing the photoresist.